Part Six for EPA-R6-2013-009697

INVENTORIES

AI ID: 289 - Honeywell International Inc - Baton Rouge South Works
Activity Number: PER20100001
Permit Number: 0840-00001-V4
Air - Title V Regular Permit Minor Mod

Subject Item Inventory:

ID	Description	Tank Volume	Max. Operating Rate	Normal Operating Rate	Contents	Operating Time
General Plant Areas						
EQT 0120	865 - Tank 134					8760 hr/yr
EQT 0121	866 - G-143a GDT	4652 gallons				8760 hr/yr
EQT 0122	867R - Genetron Washwater Tank (Iron Pond)	39105 gallons		.1 MM gallons/yr		8760 hr/yr
EQT 0123	868 - Tank 170	19976 gallons				8760 hr/yr
EQT 0124	869 - Gasoline Tank	1050 gallons		7000 gallons/yr		8760 hr/yr
EQT 0125	870 - G-143a WDT	4652 gallons				8760 hr/yr
EQT 0126	871 - Tank I-84					8760 hr/yr
EQT 0127	872 - Tank 238	23879 gallons				8760 hr/yr
EQT 0128	873 - Tank U-71	12510 gallons				8760 hr/yr
EQT 0129	880 - Tank U-70	19973 gallons				8760 hr/yr
EQT 0130	881 - New LT Tank					8760 hr/yr
EQT 0131	882 - W W Claricone	19600 gallons		600 gallons/min	waste water	8760 hr/yr
EQT 0132	883 - Treated WW No. 1	750000 gallons		600 gallons/min	waste water	8760 hr/yr
EQT 0133	884 - Treated WW No. 2	750000 gallons		600 gallons/min	waste water	8760 hr/yr
EQT 0134	885 - Treated WW No. 3	750000 gallons		600 gallons/min	waste water	8760 hr/yr
EQT 0135	890 - Tank 146 - PCE w/0.5% CCl4					8760 hr/yr
EQT 0146	Tank 150 - Hydrochloric Acid Storage Tank					8760 hr/yr
EQT 0147	Tank 160 - Hydrochloric Acid Storage Tank					8760 hr/yr
EQT 0148	- HCL Railcar Loading					8760 hr/yr
EQT 0149	- HCl Tank Truck Loading					8760 hr/yr
EQT 0150	920 - Video InkJet Printer					8760 hr/yr
EQT 0151	1301 - HFC-23 Destruction Unit					8760 hr/yr
FUG 0001	1013 - General Plant Fugitive Emissions					8760 hr/yr
FUG 0002	1013A - Hose Disconnection Fugitives					8760 hr/yr
RLP 0007	1021 - Laboratory Vent Hoods					8760 hr/yr
RLP 0013	888 - Vessel Purging for Maintenance					(None Specified)
RLP 0014	901 - Paint Dust Collector Vent					(None Specified)
RLP 0015	902 - Paint Booth Vent			8900 ft^3/min		8760 hr/yr
RLP 0016	903 - Paint Dryer Vent			8900 ft^3/min		8760 hr/yr
RLP 0017	905 - Jug Vacuum Pump and Fill Station Vent		8000 (other units)			8760 hr/yr
RLP 0018	905A - G-134A UV-Dye Jug Vent		2100 (other units)			8760 hr/yr
RLP 0019	906 - Cylinder Vacuum Pump & Fill Station Vent					(None Specified)
RLP 0020	913 - Reclamation Unit Vent-Todack		10 (other units)			8760 hr/yr
RLP 0021	914 - Reclamation Unit Vent-Cylinder Line					8760 hr/yr
RLP 0022	891 - Vessel Purging for Product Specification					8760 hr/yr
RLP 0027	887 - Vessel Purging for Product Changes					8760 hr/yr
RLP 0028	889 - Packaging Line Vapor Lock Purges					8760 hr/yr
RLP 0029	905B - Canadian Jug Vacuum Pump and Fill Station			500 (other units)		8760 hr/yr
RLP 0030	906A - G-22 Recovery System Relief Valve					(None Specified)

INVENTORIES

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Air - Title V Regular Permit Minor Mod

Subject Item Inventory:

ID	Description	Tank Volume	Max. Operating Rate	Normal Operating Rate	Contents	Operating Time
General Plant Areas						
EQT 0081	822 - Tank No. 148	101523 gallons			carbon tetrachloride	8760 hr/yr
EQT 0082	823 - Tank No. 120	17626 gallons				8760 hr/yr
EQT 0083	829 - G-113 Product Tank, No. 149	90131 gallons		6.55 MM gallons/yr		8760 hr/yr
EQT 0084	830 - Perchloroethylene Tank, No. 147	170427 gallons		19.9 MM gallons/yr		8760 hr/yr
EQT 0085	831 - Tank U-10	9892 gallons				8760 hr/yr
EQT 0086	832 - Tank U-20	9900 gallons				8760 hr/yr
EQT 0087	833 - Tank U-50	8647 gallons				8760 hr/yr
EQT 0088	834 - Tank U-60	6099 gallons				8760 hr/yr
EQT 0089	835 - Tank U-69	19973 gallons				8760 hr/yr
EQT 0090	836 - Tank 10	19973 gallons				8760 hr/yr
EQT 0091	837 - Tank 146	64936 gallons				8760 hr/yr
EQT 0092	838 - Tank 200	14604 gallons				8760 hr/yr
EQT 0093	839 - New G-12 Tank	14220 gallons				8760 hr/yr
EQT 0094	840 - Tank U-62	19973 gallons				8760 hr/yr
EQT 0095	841 - Tank 140	20473 gallons				8760 hr/yr
EQT 0096	842 - Tank 141	20473 gallons				8760 hr/yr
EQT 0097	843 - Tank 142	20473 gallons				8760 hr/yr
EQT 0098	844 - Tank 143	20473 gallons				8760 hr/yr
EQT 0099	845 - Tank 239	22397 gallons				8760 hr/yr
EQT 0100	846 - Tank 240	22397 gallons				8760 hr/yr
EQT 0101	847 - Tank 132	22974 gallons				8760 hr/yr
EQT 0102	848 - Tank U-149	91334 gallons				8760 hr/yr
EQT 0103	849 - Tank 11	19973 gallons				8760 hr/yr
EQT 0104	850 - Tank 12	19973 gallons				8760 hr/yr
EQT 0105	851 - Tank 41	19973 gallons				8760 hr/yr
EQT 0106	852 - Tank 42	19973 gallons				8760 hr/yr
EQT 0107	853 - Tank 43	19973 gallons				8760 hr/yr
EQT 0108	854 - Tank 46	17465 gallons				8760 hr/yr
EQT 0109	855A - Tank 1 - Chloroform Storage Tank	146915 gallons				8760 hr/yr
EQT 0110	855B - Tank 2 - CCL4 Storage Tank	146915 gallons				8760 hr/yr
EQT 0111	856 - Tank 60	19973 gallons				8760 hr/yr
EQT 0112	857 - G-114 NDT	2710 gallons				8760 hr/yr
EQT 0113	858 - G-114 SDT	2710 gallons				8760 hr/yr
EQT 0114	859 - Tank 144	20473 gallons				8760 hr/yr
EQT 0115	860 - Tank 145	20473 gallons				8760 hr/yr
EQT 0116	861 - G-123 KDT	3878 gallons				8760 hr/yr
EQT 0117	862 - Tank 40	19973 gallons				8760 hr/yr
EQT 0118	863 - Tank 125	20762 gallons				8760 hr/yr
EQT 0119	864 - Tank 100	14604 gallons				8760 hr/yr

INVENTORIES

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Air - Title V Regular Permit Minor Mod

Subject Item Inventory:

ID	Description	Tank Volume	Max. Operating Rate	Normal Operating Rate	Contents	Operating Time
General Plant Areas						
EQT 0009	1001 - Wastewater Air Stripper			10400 ft^3/min		8760 hr/yr
EQT 0010	1002 - Boiler No. 3		45.2 MM BTU/hr			8760 hr/yr
EQT 0011	1003 - Boiler No. 4		50 MM BTU/hr			8760 hr/yr
EQT 0012	1004 - Main Cooling Water Tower		9300 gallons/min	4888 MM gallons/yr		8760 hr/yr
EQT 0013	1005 - G-1113 Cooling Water Tower		585 gallons/min	307.5 MM gallons/yr		8760 hr/yr
EQT 0014	1006 - NUTEMP Cooling Water Tower		100 gallons/min	52.6 MM gallons/yr		8760 hr/yr
EQT 0015	1007 - G-1113 Refrigeration System					8760 hr/yr
EQT 0016	1008 - G-22 Refrigeration System					8760 hr/yr
EQT 0017	1009 - OMNI Refrigeration System					8760 hr/yr
EQT 0018	1010 - Chilled Water System No. 1					8760 hr/yr
EQT 0019	1012 - Chilled Water System No. 3					8760 hr/yr
EQT 0020	1014 - Blending Cooling Water Tower		300 gallons/min	158 MM gallons/yr		8760 hr/yr
EQT 0021	1017 - Blends Chilled Water System					8760 hr/yr
EQT 0022	1019 - Cooling Tower No. 4		2200 gallons/min	1156.3 MM gallons/yr		8760 hr/yr
EQT 0023	1020 - Portable Refrigeration System					8760 hr/yr
EQT 0031	1205 - Diesel Fire Pump, No. 35		85 horsepower			8760 hr/yr
EQT 0032	1206 - HF Mitigation Generator, No. 53		700 horsepower			8760 hr/yr
EQT 0033	1207 - ETF Emergency Generator, No. 51		1480 horsepower			8760 hr/yr
EQT 0035	1209 - 375 Air Compressor, No. 14		109 horsepower			8760 hr/yr
EQT 0050	501 - CaCl2 Lime Silo Baghouse			10 MM lbs/yr		8760 hr/yr
EQT 0051	502 - CaCl2 Plant Vent Scrubber		1980 SCFM	1980 SCFM		8760 hr/yr
EQT 0052	503 - G03 ST HCL Scrubber		46.2 MM gallons/yr	46.2 MM gallons/yr		8760 hr/yr
EQT 0053	701 - HF Storage Tanks Scrubber			3449 ft^3/min		8760 hr/yr
EQT 0054	801 - HCl Scrubber		46.2 MM gallons/yr	46.2 MM gallons/yr		8760 hr/yr
EQT 0055	802 - Tank 51-Spent H2SO4 Tank	23879 gallons		.95 MM gallons/yr	sulfuric acid	8760 hr/yr
EQT 0056	803 - Tank 50-Fresh H2SO4 Tank	12510 gallons		.95 MM gallons/yr	sulfuric acid	8760 hr/yr
EQT 0057	804 - Tank 52-Spent H2SO4 Tank	19973 gallons		.95 MM gallons/yr	sulfuric acid	8760 hr/yr
EQT 0063	886 - Process Sump			600 gallons/min		8760 hr/yr
EQT 0066	901A - Blasting Material Hopper					8760 hr/yr
EQT 0067	901B - Blasting Drum Collector					8760 hr/yr
EQT 0071	907 - Packaging Drumming Operations					8760 hr/yr
EQT 0072	907A - G-123 ISO Loading			.12 MM gallons/yr		8760 hr/yr
EQT 0073	912 - Solvent Wash Stations					8760 hr/yr
EQT 0074	913A - Todack Oil Drumming			660 gallons/yr		8760 hr/yr
EQT 0075	915 - Paint Thinner Drum			4858 gallons/yr		8760 hr/yr
EQT 0076	916 - Reclamation Unit - Packaging Line		10 (other units)	8760 (other units)		8760 hr/yr
EQT 0077	917 - Spent Sulfuric Acid Loading		100 gallons/min	.95 MM gallons/yr		8760 hr/yr
EQT 0078	918 - G-113 Loading		100 gallons/min	1.5 MM lbs/yr		8760 hr/yr
EQT 0079	919 - Ton/Half Ton Cylinder Painting					8760 hr/yr

INVENTORIES

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ID	Description	Tank Volume	Max. Operating Rate	Normal Operating Rate	Contents	Operating Time
G-1113 Process Unit						
EQT 0017	1009 - OMNI Refrigeration System					8760 hr/yr
EQT 0042	202 - Zinc Blow Pot and Unloading System Baghouse					8760 hr/yr
EQT 0043	203 - Zinc Day Tank Baghouse			.25 tons/hr		8760 hr/yr
EQT 0058	805 - Tank 47-Methanol Tank	10528 gallons			methanol	8760 hr/yr
EQT 0059	812 - Tank 70 -- G-1113 Process Water	19600 gallons		.37 MM gallons/yr	Process Water	8760 hr/yr
EQT 0060	813 - Tank 62 -- G-1113 Process Water	750000 gallons		.37 MM gallons/yr	Process Water	8760 hr/yr
EQT 0061	814 - Tank 61 -- G-1113 Process Water	750000 gallons		.37 MM gallons/yr	Process Water	8760 hr/yr
EQT 0062	815 - Process Sump			35 gallons/min		8760 hr/yr
FUG 0007	206 - G-1113 Unit Fugitive Emissions					8760 hr/yr
RLP 0008	201 - G-1113 Vent		177 SCFM	177 SCFM		8760 hr/yr
G-22 Process Unit						
EQT 0024	105 - G-13 Vent Condenser (G-22 Unit)					8760 hr/yr
EQT 0025	109-(G-22(11/12)) - Catalyst Sampling (G-22 Unit)					8760 hr/yr
EQT 0026	109-(G-22(113/114)) - Catalyst Sampling (G-22 Unit)					8760 hr/yr
EQT 0027	109-(G-22(143a)) - Catalyst Sampling (G-22 Unit)					8760 hr/yr
EQT 0028	109-(G-22(22)) - Catalyst Sampling (G-22 Unit)					8760 hr/yr
FUG 0003	104 - G-22 Unit Fugitive Emissions (G-22 Unit)					8760 hr/yr
FUG 0004	106 - G-11/12 Production Fugitive Emissions (G-22 Unit)					8760 hr/yr
FUG 0005	107 - G-143a Production Fugitive Emissions (G-22 Unit)					8760 hr/yr
FUG 0006	108 - G-113/114 Production Fugitive Emissions (G-22 Unit)					8760 hr/yr
RLP 0006	102 - G-22 Process Vent (G-22 Unit)		26.9 SCFM	26.9 SCFM		8760 hr/yr

for the preceding six month calendar period shall be included with the semiannual monitoring report required by Part 70, General Condition K.

Note: This requirement resulted from NSR rules whereby the permittee agreed to accept a permanent, enforceable limit on facility-wide G-22 production to avoid full PSD review. The enforceable limit maintains project related emission increases of ozone depleting substance (ODS) from the 2001 G-22 production increase below the PSD significance level of 100 tons/year.

40 CFR PART 70 SPECIFIC CONDITIONS

Baton Rouge Plant
Agency Interest No.: 289
Honeywell International Inc.
Baton Rouge, East Baton Rouge Parish, Louisiana

Unit or Plant Site	Fugitive Source Description	Programs Being Streamlined	Stream Applicability	Overall Most Stringent Program
General Plant Areas	1013 General Plant Fugitive Emissions			
G-22 Unit	104 G-22 Production Fugitive Emissions			
	106 G-11/12 Production Fugitive Emissions			
	107 G-143a Production Fugitive Emissions			
	108 G-113/114 Production Fugitive Emissions	40 CFR 63 Subpart H (HON)	5% VOHAP	
Omni Unit	307 G-113/114 Production Fugitive Emissions	La Non-HON MACT	5% Class I & II TAPs	40 CFR 63 Subpart H (HON)
	305 G-143a Production Fugitive Emissions	LAC 33:III.2122	10% VOC	
	306 G-11/12 Production Fugitive Emissions			
	308 G-22 Production Fugitive Emissions			
	309 G-143a & G-113/114 Fugitive Emissions			
G-1113 Unit	206 – G-1113 Unit Fugitive Emissions			

2. Permittee shall limit the facility-wide maximum annual G-22 production to 188 million pounds. G-22 production shall be recorded each month, as well as the total G-22 production for the last twelve months. These records shall be kept on site and available for inspection by the Office of Environmental Compliance, Surveillance Division. G-22 production above the maximum listed in this specific condition for any twelve consecutive month period shall be a violation of this permit and must be reported to the Office of Environmental Compliance, Enforcement Division. A report showing the monthly G-22 production and the cumulative 12 month totals

40 CFR PART 70 SPECIFIC CONDITIONS

Baton Rouge Plant
Agency Interest No.: 289
Honeywell International Inc.
Baton Rouge, East Baton Rouge Parish, Louisiana

1. Permittee shall comply with a streamlined equipment leaks monitoring program. Compliance with the streamlined program in accordance with this specific condition shall serve to comply with each of the applicable fugitive emission monitoring programs being streamlined, as indicated in the following table. Noncompliance with the streamlined program in accordance with this specific condition may subject the permittee to enforcement action for one or more of the applicable fugitive emissions programs.

    a. Permittee shall apply the streamlined program to the combined universe of components subject to any of the programs being streamlined. Any component type which does not require periodic monitoring under the overall most stringent program (HON) shall be monitored as required by the most stringent requirements of any other program being streamlined and will not be exempted. The streamlined program will include any exemptions based on size of component available in any of the programs being streamlined.

    b. Permittee shall use leak definitions and monitoring frequency based on the overall most stringent program. Percent leaker performance shall be calculated using the provisions of the overall most stringent program. Annual monitoring shall be defined as once every four quarters. Some allowance may be made in the first year of the streamlined program in order to allow for transition from existing monitoring schedules.

    c. Permittee shall comply with the recordkeeping and reporting requirements of the overall most stringent program. Semiannual reports shall be submitted on September 30 and March 31, to cover the periods January 1 through June 30 and July 1 through December 31, respectively. The semiannual reports shall include any monitoring performed within the reporting period.

STATE-ONLY SPECIFIC CONDITIONS

Baton Rouge Plant
Agency Interest No.: 289
Honeywell International Inc.
Baton Rouge, East Baton Rouge Parish, Louisiana

1. The number of each type of component required to be monitored for each monitoring period under applicable leak detection and repair programs shall be reported to the LDEQ by inclusion with each periodic monitoring report. Fugitive emission piping components may be added to or removed from the permitted units, without triggering the need to apply for a permit modification, provided:

    a. Changes in components involve routine maintenance, or are undertaken to address safety concerns, or involve small piping revisions with no associated emission increases except from the fugitive components themselves;

    b. The changes do not involve any associated increase in production rate or capacity, or tie in of new or modified process equipment other than piping components;

    c. Actual emissions following the changes will not exceed the emission limits contained in this permit; and

    d. The components are promptly incorporated into any applicable leak detection and repair program.

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
EQT047	**310** – Catalyst Sampling	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2115 Waste Gas Disposal	**DOES NOT APPLY.** Vent stream does not contain VOCs.

The above table provides explanation for both the exemption status or non-applicability of a source cited by 1, 2 or 3 in the matrix presented in Section X (Table 1) of this permit.

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
FUG009	**306** – G-11/12 Fugitive Emissions	40 CFR 60 Subpart VV Standards of Performance for Equipment Leaks of VOC in SOCMI (40 CFR 60.480)	**DOES NOT APPLY.** Unit was constructed prior to January 5, 1981 and has not been modified or reconstructed. [40 CFR 60.480(b)]
		40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.
EQT044	**310** – Catalyst Sampling	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2115 Waste Gas Disposal	**DOES NOT APPLY.** Vent stream does not contain VOCs.
Omni Process Unit: G-22 Production			
FUG011	**308** – G-22 Production Fugitive Emissions	40 CFR 60 Subpart VV Standards of Performance for Equipment Leaks of VOC in SOCMI (40 CFR 60.480)	**DOES NOT APPLY.** Unit was constructed prior to January 5, 1981 and has not been modified or reconstructed. [40 CFR 60.480(b)]
		40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
(continued) **RLP009**	**304** – Spent Caustic Vent	40 CFR 60 Subpart RRR Standards of Performance for VOC Emissions from SOCMI Reactor Processes	**DOES NOT APPLY.** Source was constructed before June 29, 1990 and has not been modified or reconstructed. [40 CFR 60.700(b)]
		40 CFR 63.113 SOCMI HON – Process Vent Provisions	**DOES NOT APPLY.** Organic HAP concentration is less than 0.005 weight percent.
		40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.
		40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Emission unit does not use a control device to achieve compliance with a Federally applicable requirement [40 CFR 64.2(a)(2)]
		LAC 33:III.2115 Waste Gas Disposal	**EXEMPT.** The administrative authority may waive the requirements of this Section if disposal of the the waste gas cannot be practically or safely accomplished without causing undue economic hardship. [LAC 33:III.2115.H.2.b] A request for a waiver from LAC 33:III.2115 was included with the application for Honeywell's initial Part 70 permit because the cost of control of VOC emissions from this source would result in undue economic hardship. [LAC 33:III.2115.H.2.b]

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
(continued) EQT138	**312** – G-134a cGMP Vent Condenser	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2115 Waste Gas Disposal	**EXEMPT.** Vent stream does not emit more than 100 pounds of VOC in any continuous 24-hour period. [LAC 33:III.2115.H.1.c]
FUG014	**313** – G-134a cGMP Fugitive Emissions	40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** Source does not service an MCPU which uses or produces a HAP as an intermediate or final product. [40 CFR 63.2435]
		40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2122 Fugitive Emission Control for Ozone Nonattainment Areas	**DOES NOT APPLY.** Process stream contains less than 10% VOC by volume.
Omni Process Unit: G-11/12 Production			
RLP009	**304** – Spent Caustic Vent	40 CFR 60 Subpart NNN Standards of Performance for VOC Emissions from SOCMI Distillation Operations	**DOES NOT APPLY.** Source was constructed before December 30, 1983 and has not been modified or reconstructed. [40 CFR 60.660(b)]

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
(continued) **RLP011**	**304** – Spent Caustic Vent	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2115 Waste Gas Disposal	**EXEMPT.** Vent stream does not emit more than 100 pounds of VOC in any continuous 24-hour period. [LAC 33:III.2115.H.1.c]
		LAC 33:III.5109 Emission Control and Reduction Requirements and Standards	**DOES NOT APPLY.** Organic HAP concentration is less than 0.005 weight percent.
FUG008	**305** – G-143a Fugitive Emissions	40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.
EQT046	**310** – Catalyst Sampling	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2115 Waste Gas Disposal	**DOES NOT APPLY.** Vent stream does not contain VOCs.
EQT138	**312** – G-134a cGMP Vent Condenser	40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** Vent condenser does not service an MCPU which uses or produces a HAP as an intermediate or final product. [40 CFR 63.2435]

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
FUG010	**307** – G-113/114 Fugitive Emissions	40 CFR 60 Subpart VV Standards of Performance for Equipment Leaks of VOC in SOCMI (40 CFR 60.480)	**DOES NOT APPLY.** Unit was constructed prior to January 5, 1981 and has not been modified or reconstructed. [40 CFR 60.480(b)]
		40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.
EQT045	**310** – Catalyst Sampling	LAC 33:III.2115 Waste Gas Disposal	**DOES NOT APPLY.** Vent stream does not contain VOCs.
		40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
Omni Process Unit: G-143a & G-134a cGMP Production			
RLP011	**304** – Spent Caustic Vent	40 CFR 63.113 SOCMI HON – Process Vent Provisions	**DOES NOT APPLY.** Organic HAP concentration is less than 0.005 weight percent.
		40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
(continued) **RLP010**	**304** – Spent Caustic Vent	40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.
		40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Emission unit does not use a control device to achieve compliance with a Federally applicable requirement [40 CFR 64.2(a)(2)]
		LAC 33:III.2115 Waste Gas Disposal	**EXEMPT.** The administrative authority may waive the requirements of this Section if disposal of the the waste gas cannot be practically or safely accomplished without causing undue economic hardship. [LAC 33:III.2115.H.2.b] A request for a waiver from LAC 33:III.2115 was included with the application for Honeywell's initial Part 70 permit because the cost of control of VOC emissions from this source would result in undue economic hardship. [LAC 33:III.2115.H.2.b]
		LAC 33:III.5109 Comprehensive TAP Emission Control Program – Emission Control and Reduction Requirements and Standards	**DOES NOT APPLY.** Organic HAP concentration is less than 0.005 weight percent.

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
(continued) **EQT059** **EQT060** **EQT061**	**812** – G-1113 Process Water Tank, No. 70 **813** – G-1113 Process Water Tank, No. 62 **814** – G-1113 Process Water Tank, No. 61	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Sources do not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as major sources. [40 CFR 64.2(a)(3)]
		LAC 33:III.2103 Storage of Volatile Organic Compounds	**DOES NOT APPLY.** Tank s do not store organic liquids with vapor pressures greater than 1.5 psia.
EQT062	**815** – Process Sump	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2153 Limiting Volatile Organic Compound Emissions from Industrial Wastewater	**DOES NOT APPLY.** All process water is returned to the process and is not discharged. [LAC 33:III.2153.B]
Omni Process Unit: G-113/114 Production			
RLP010	**304** – Spent Caustic Vent	40 CFR 60 Subpart RRR Standards of Performance for VOC Emissions from SOCMI Reactor Processes	**DOES NOT APPLY.** Vent stream discharges through a distillation unit that is regulated under 40 CFR 60 Subpart NNN.
		40 CFR 63.113 SOCMI HON – Process Vent Provisions	**DOES NOT APPLY.** Organic HAP concentration is less than 0.005 weight percent.

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
(continued) **EQT042** **EQT043**	**202** – Zinc Blowpot and Unloading System **203** – Zinc Day Tank Baghouse	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Sources do not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as major sources. [40 CFR 64.2(a)(3)]
FUG007	**206** – G-1113 Fugitive Emissions	40 CFR 63 Subpart EEEE NESHAP: Organic Liquids Distribution (Non-Gasoline)	**DOES NOT APPLY.** Fugitive emissions from potentially affected equipment components are regulated under 40 CFR 63 Subpart FFFF. [40 CFR 63.2338(c)(1) and (2)]
		40 CFR 63 Subpart NNNNN NESHAP: Hydrochloric Acid Production	**DOES NOT APPLY.** Unit does not produce hydrochloric acid.
		LAC 33:III.2122 Fugitive Emission Control for Ozone Nonattainment Areas	**DOES NOT APPLY.** Unit does not produce a SOCMI chemical.
EQT058	**805** – Methanol Tank, No. 47	40 CFR 63 Subpart EEEE NESHAP: Organic Liquids Distribution (Non-Gasoline)	**DOES NOT APPLY.** Storage tank is regulated under 40 CFR 63, Subpart FFFF. [40 CFR 63.2338(c)(1) and (2)]
		40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
EQT059 **EQT060** **EQT061**	**812** – G-1113 Process Water Tank, No. 70 **813** – G-1113 Process Water Tank, No. 62 **814** – G-1113 Process Water Tank, No. 61	40 CFR 63 Subpart EEEE NESHAP: Organic Liquids Distribution (Non-Gasoline)	**DOES NOT APPLY.** Storage tanks are regulated under 40 CFR 63, Subpart FFFF. [40 CFR 63.2338(c)(1) and (2)]

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source			
TEMPO ID No:	**Description**	**Requirement**	**Notes**
G-1113 Process Unit			
RLP008	**201** – G-1113 Unit Vent	40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**CONTROL REQUIREMENTS DO NOT APPLY.** Source is a Group 2 MON vent. Permittee shall comply only with applicable reporting and recordkeeping requirements.
		LAC 33:III.2115 Waste Gas Disposal	**EXEMPT.** The administrative authority may waive the requirements of this Section if disposal of the waste gas cannot be practically or safely accomplished without causing undue economic hardship. [LAC 33:III.2115.H.2.b] A request for a waiver from LAC 33:III.2115 was included with the application for Honeywell's initial Part 70 permit because the cost of control of VOC emissions from this source would result in undue economic hardship. [LAC 33:III.2115.H.2.b]
		40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Emission unit does not use a control device to achieve compliance with a Federally applicable requirement [40 CFR 64.2(a)(2)]
EQT042 **EQT043**	**202** – Zinc Blowpot and Unloading System **203** – Zinc Day Tank Baghouse	40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** Sources do not emit HAPs.

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
G-22 Process Unit: G-113/114 Production			
FUG006	**108** – G-113/114 Production Fugitive Emissions	40 CFR 60 Subpart VV Standards of Performance for Equipment Leaks of VOC in SOCMI (40 CFR 60.480)	**DOES NOT APPLY.** Unit was constructed prior to January 5, 1981 and has not been modified or reconstructed. [40 CFR 60.480(b)]
		40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY.** The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.
EQT026	**109** – (G-22(113/114)) - Catalyst Sampling	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2115 Waste Gas Disposal	**DOES NOT APPLY.** Vent stream does not contain VOCs.

XI. Table 2. Explanation for Exemption Status or Non-Applicability of a Source

TEMPO ID No:	Description	Requirement	Notes
EQT025	**109** – (G-22(11/12)) - Catalyst Sampling	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2115 Waste Gas Disposal	**DOES NOT APPLY**. Vent stream does not contain VOCs
G-22 Process Unit: G-143a Production			
FUG005	**107** – G-143a Production Fugitive Emissions	40 CFR 63 Subpart FFFF NESHAP: Miscellaneous Organic Chemical Manufacturing (MON)	**DOES NOT APPLY**. The CMPU is an affected source under another subpart in 40 CFR 63. [40 CFR 63.2435(b)(3)] The CMPU is subject to HON 40 CFR 63 Subpart H.
EQT027	**109** – (G-22(143a)) - Catalyst Sampling	40 CFR 64 Compliance Assurance Monitoring (CAM)	**DOES NOT APPLY.** Source does not have pre-control device emissions of a regulated pollutant equal to or greater than 100% of the amount, in tons per year, required for the sources to be classified as a major source. [40 CFR 64.2(a)(3)]
		LAC 33:III.2115 Waste Gas Disposal	**DOES NOT APPLY**. Vent stream does not contain VOCs.

SPECIFIC REQUIREMENTS

AI ID: 289 - Honeywell International Inc - Baton Rouge South Works
Activity Number: PER20100001
Permit Number: 0840-00001-V4
Air - Title V Regular Permit Minor Mod

Group: PCS 0003 G-1113 Process Unit

Group Members: EQT 0017 EQT 0042 EQT 0043 EQT 0058 EQT 0059 EQT 0060 EQT 0061 EQT 0062 FUG 0007 RLP 0008

EQT 0017 1009 - OMNI Refrigeration System

1	[40 CFR 82.156]	Owners and operators of industrial process equipment containing more than 50 pounds of refrigerant must have leaks repaired if the appliance is leaking at such a rate that the loss of refrigerant will exceed 35 percent during a 12-month period. If the leaks cannot be repaired, the equipment must be retrofitted or replaced. Reports must be filed with the EPA as per these regulations. Test must be made to verify that the repairs were successful.

EQT 0042 202 - Zinc Blow Pot and Unloading System Baghouse

2	[LAC 33:III.1311.C]	Opacity <= 20 percent; except emissions may have an average opacity in excess of 20 percent for not more than one six-minute period in any 60 consecutive minutes. Which Months: All Year Statistical Basis: Six-minute average
3	[LAC 33:III.501.C.6]	Filter vents: Visible emissions monitored by visual inspection/determination daily. If visible emissions are observed, restore operation of the filter to its normal or usual manner of operation as expeditiously as practicable, but at a minimum within three working days, in accordance with good air pollution control practices for minimizing emissions. Which Months: All Year Statistical Basis: None specified
4	[LAC 33:III.501.C.6]	Particulate matter (10 microns or less) >= 99 % removal efficiency from filter manufacturer's certification. Which Months: All Year Statistical Basis: None specified
5	[LAC 33:III.501.C.6]	Baghouses: Equipment/operational data recordkeeping by electronic or hard copy upon each occurrence of inspection. Keep records of maintenance inspections on site and available for inspection by the Office of Environmental Compliance, Surveillance Division.
6	[LAC 33:III.501.C.6]	Filter vents: Visible emissions recordkeeping by electronic or hard copy daily. Keep records of visible emission checks on site and available for inspection by the Office of Environmental Compliance, Surveillance Division.
7	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits a Class III TAP only. MACT is not required.

EQT 0043 203 - Zinc Day Tank Baghouse

8	[LAC 33:III.1311.C]	Opacity <= 20 percent; except emissions may have an average opacity in excess of 20 percent for not more than one six-minute period in any 60 consecutive minutes. Which Months: All Year Statistical Basis: Six-minute average
9	[LAC 33:III.501.C.6]	Filter vents: Visible emissions monitored by visual inspection/determination daily. If visible emissions are observed, restore operation of the filter to its normal or usual manner of operation as expeditiously as practicable, but at a minimum within three working days, in accordance with good air pollution control practices for minimizing emissions. Which Months: All Year Statistical Basis: None specified
10	[LAC 33:III.501.C.6]	Baghouses: Equipment/operational data recordkeeping by electronic or hard copy upon each occurrence of inspection. Keep records of maintenance inspections on site and available for inspection by the Office of Environmental Compliance, Surveillance Division.

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EQT 0043 203 - Zinc Day Tank Baghouse

11	[LAC 33:III.501.C.6]	Filter vents: Visible emissions recordkeeping by electronic or hard copy daily. Keep records of visible emission checks on site and available for inspection by the Office of Environmental Compliance, Surveillance Division.
12	[LAC 33:III.501.C.6]	Particulate matter (10 microns or less) >= 99 % removal efficiency from filter manufacturer's certification. Which Months: All Year Statistical Basis: None specified
13	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits a Class III TAP only. MACT is not required.

EQT 0058 805 - Tank 47-Methanol Tank

14	[40 CFR 63.2470]	Storage tank shall comply with all applicable provisions of 40 CFR 63.2470 of Subpart FFFF. Tank is not subject to control standards because it has a volume of less than 10,000 gallons and is a Group 2 storage tank as per the definition for existing sources in 40 CFR 63.2550. Subpart FFFF.
15	[40 CFR 63.2520(a)]	Submit each report listed in Table 11 of 40 CFR 63 Subpart FFFF as applicable. Keep records specified in 40 CFR 63.2525(a) through (k). Subpart FFFF. [40 CFR 63.2520(a), 40 CFR 63.2525(a-k)]
16	[LAC 33:III.2103.A]	Equip with a submerged fill pipe.
17	[LAC 33:III.2103.H.3]	Determine VOC maximum true vapor pressure using the methods in LAC 33:III.2103.H.3.a-e.
18	[LAC 33:III.2103.I]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Keep records of the information specified in LAC 33:III.2103.I.1 - 7, as applicable.
19	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits a Class III TAP only. MACT is not required.

EQT 0059 812 - Tank 70 -- G-1113 Process Water

20	[40 CFR 63.2470]	Storage tank shall comply with all applicable provisions of 40 CFR 63.2470 of Subpart FFFF. Tank is not subject to control standards because it stores a material that has a maximum true vapor pressure of total HAPs of less than 6.9 kilopascals (1.0 psia). Tank is a Group 2 storage tank as per the definition for existing sources in 40 CFR 63.2550. Subpart FFFF.
21	[40 CFR 63.2520(a)]	Submit each report listed in Table 11 of 40 CFR 63 Subpart FFFF as applicable. Keep records specified in 40 CFR 63.2525(a) through (k). Subpart FFFF. [40 CFR 63.2520(a), 40 CFR 63.2525(a-k)]
22	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits a Class III TAP only. MACT is not required.

EQT 0060 813 - Tank 62 -- G-1113 Process Water

23	[40 CFR 63.2470]	Storage tank shall comply with all applicable provisions of 40 CFR 63.2470 of Subpart FFFF. Tank is not subject to control standards because it stores a material that has a maximum true vapor pressure of total HAPs of less than 6.9 kilopascals (1.0 psia). Tank is a Group 2 storage tank as per the definition for existing sources in 40 CFR 63.2550. Subpart FFFF.

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EQT 0060 813 - Tank 62 -- G-1113 Process Water

24	[40 CFR 63.2520(a)]	Submit each report listed in Table 11 of 40 CFR 63 Subpart FFFF as applicable. Keep records specified in 40 CFR 63.2525(a) through (k). Subpart FFFF. [40 CFR 63.2520(a), 40 CFR 63.2525(a-k)]
25	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits a Class III TAP only. MACT is not required.

EQT 0061 814 - Tank 61 -- G-1113 Process Water

26	[40 CFR 63.2470]	Storage tank shall comply with all applicable provisions of 40 CFR 63.2470 of Subpart FFFF. Tank is not subject to control standards because it stores a material that has a maximum true vapor pressure of total HAPs of less than 6.9 kilopascals (1.0 psia). Tank is a Group 2 storage tank as per the definition for existing sources in 40 CFR 63.2550. Subpart FFFF.
27	[40 CFR 63.2520(a)]	Submit each report listed in Table 11 of 40 CFR 63 Subpart FFFF as applicable. Keep records specified in 40 CFR 63.2525(a) through (k). Subpart FFFF. [40 CFR 63.2520(a), 40 CFR 63.2525(a-k)]
28	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits a Class III TAP only. MACT is not required.

EQT 0062 815 - Process Sump

29	[40 CFR 63.2485(a)]	Comply with the requirements in 40 CFR 63.149 and the requirements referenced therein, except as specified in 40 CFR 63.2485. Subpart FFFF. [40 CFR 63.2485(a)]
30	[40 CFR 63.2485(j)]	Determine the annual average concentration and annual average flowrate for wastewater streams for each MCPU. Subpart FFFF. [40 CFR 63.2485(j)]
31	[40 CFR 63.2525]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Keep records of the information specified in 40 CFR 63.2525(a) through (k), as applicable. Subpart FFFF.
32	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits a Class III TAP only. MACT is not required.

FUG 0007 206 - G-1113 Unit Fugitive Emissions

33	[40 CFR 63.162(c)]	Identify each piece of equipment in a process unit such that it can be distinguished readily from equipment that is not subject to 40 CFR 63 Subpart H. Subpart H. [40 CFR 63.162(c)]
34	[40 CFR 63.162(f)]	Clearly identify leaking equipment, for leaking equipment detected as specified in 40 CFR 63.163, 40 CFR 63.164, 40 CFR 63.168, 40 CFR 63.169, and 40 CFR 63.172 through 63.174. The identification may be removed after the equipment is repaired, except for valves or for connectors subject to 40 CFR 63.174(c)(1)(i). The identification on a valve may be removed after it has been monitored as specified in 40 CFR 63.168(f)(3) and 63.175(e)(i)(D), and no leak has been detected during the follow-up monitoring. If electing to comply using the provisions of 40 CFR 63.174(c)(1)(i), the identification on a connector may be removed after it is monitored as specified in 40 CFR 63.174(c)(1)(i) and no leak is detected during that monitoring. Subpart H. [40 CFR 63.162(f)]

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FUG 0007 206 - G-1113 Unit Fugitive Emissions

35	[40 CFR 63.163(b)(1)]	Pumps in light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, except as provided in 40 CFR 63.162(b) and 63.163(e) through (j). If a reading of 10,000 ppm (phase I); 5,000 ppm (phase II); or 5,000 ppm (phase III, pumps handling polymerizing monomers), 2,000 ppm (phase III, pumps in food/medical service), or 1,000 ppm (phase III, all other pumps) or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(1)] Which Months: All Year Statistical Basis: None specified
36	[40 CFR 63.163(b)(3)]	Pumps in light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquids dripping from the pump seal, a leak is detected. If a leak is detected, initiate the repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(3)] Which Months: All Year Statistical Basis: None specified
37	[40 CFR 63.163(c)]	Pumps in light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.163(c)(3) and 40 CFR 63.171. Subpart H. [40 CFR 63.163(c)]
38	[40 CFR 63.163(d)(2)]	Pumps in light liquid service: Implement a quality improvement program for pumps that complies with the requirements of 40 CFR 63.176, if, in Phase III, calculated on a 6-month rolling average, the greater of either 10 percent of the pumps in a process unit or three pumps in a process unit leak. Subpart H. [40 CFR 63.163(d)(2)]
39	[40 CFR 63.163(d)(4)]	Pumps in light liquid service: Determine percent leaking pumps using the equation in 40 CFR 63.163(d)(4). Subpart H. [40 CFR 63.163(d)(4)]
40	[40 CFR 63.163(e)(1)]	Pumps in light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the pump stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(1)]
41	[40 CFR 63.163(e)(2)]	Pumps in light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid service. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(2)]
42	[40 CFR 63.163(e)(3)]	Pumps in light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(3)]
43	[40 CFR 63.163(e)(4)]	Pumps in light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquid dripping from the pump seal at the time of the weekly inspection, monitor the pump as specified in 40 CFR 63.180(b) to determine if there is a leak of organic HAP in the barrier fluid. If an instrument reading of 1,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(4)] Which Months: All Year Statistical Basis: None specified
44	[40 CFR 63.163(e)(6)(i)]	Pumps in light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)(i)]

Group: PCS 0003 G-1113 Process Unit

FUG 0007 206 - G-1113 Unit Fugitive Emissions

45	[40 CFR 63.163(e)(6)]	Pumps in light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)]
46	[40 CFR 63.163(e)]	Pumps in light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the pump is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.163(e)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)] Which Months: All Year Statistical Basis: None specified
47	[40 CFR 63.163(j)(1)]	Pumps in light liquid service (unsafe-to-monitor): Determine that the pump is unsafe-to-monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.163(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(1)]
48	[40 CFR 63.163(j)(2)]	Pumps in light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the pump as frequently as practicable during safe-to-monitor times but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(2)] Which Months: All Year Statistical Basis: None specified
49	[40 CFR 63.164(a)]	Compressors: Equip with a seal system that includes a barrier fluid system and that prevents leakage of process fluid to the atmosphere, except as provided in 40 CFR 63.162(b) and 40 CFR 63.164(h) and (i). Subpart H. [40 CFR 63.164(a)]
50	[40 CFR 63.164(b)]	Compressors: Operate the seal system with the barrier fluid at a pressure that is greater than the compressor stuffing box pressure; or equip with a barrier fluid system degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid directly into a process stream. Subpart H. [40 CFR 63.164(b)]
51	[40 CFR 63.164(c)]	Compressors: Ensure that the barrier fluid is not in light liquid service. Subpart H. [40 CFR 63.164(c)]
52	[40 CFR 63.164(d)]	Compressors: Equip each barrier fluid system as described in 40 CFR 63.164(a) through (c) with a sensor that will detect failure of the seal system, barrier fluid system, or both. Subpart H. [40 CFR 63.164(d)]
53	[40 CFR 63.164(e)(2)]	Compressors (sensor): Determine, based on design considerations and operating experience, a criterion that indicates failure of the seal system, the barrier fluid system, or both. Subpart H. [40 CFR 63.164(e)(2)]
54	[40 CFR 63.164(g)]	Compressors: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.164(g)]
55	[40 CFR 63.164(i)(2)]	Compressors (no detectable emissions): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially and annually, and at other times requested by DEQ. Comply with this requirement instead of the requirements in 40 CFR 63.164(a) through (h). Subpart H. [40 CFR 63.164(i)(2)] Which Months: All Year Statistical Basis: None specified

Group: PCS 0003 G-1113 Process Unit

FUG 0007 206 - G-1113 Unit Fugitive Emissions

56	[40 CFR 63.164]	Compressors (sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an alarm, unless the compressor is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criterion determined under 40 CFR 63.164(e)(2), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.164(g). Subpart H. Which Months: All Year Statistical Basis: None specified
57	[40 CFR 63.165(a)]	Pressure relief device in gas/vapor service: Organic HAP < 500 ppm above background except during pressure releases, as determined by the method specified in 63.180(c). Subpart H. [40 CFR 63.165(a)] Which Months: All Year Statistical Basis: None specified
58	[40 CFR 63.165(b)(1)]	Pressure relief devices in gas/vapor service: After each pressure release, return to a condition indicated by an instrument reading of less than 500 ppm above background, as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.165(b)(1)]
59	[40 CFR 63.165(b)(2)]	Pressure relief devices in gas/vapor service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) after the pressure release and being returned to organic HAP service, to confirm the condition indicated by an instrument reading of less than 500 ppm above background, as measured by the method specified in 40 CFR 63.180(c). Subpart H. [40 CFR 63.165(b)(2)] Which Months: All Year Statistical Basis: None specified
60	[40 CFR 63.165(d)(2)]	Pressure relief devices in gas/vapor service (rupture disk): After each pressure release, install a new rupture disk upstream of the pressure relief device as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.165(a) and (b). Subpart H. [40 CFR 63.165(d)(2)]
61	[40 CFR 63.166]	Sampling connection systems: Equip with a closed-purge, closed-loop, or closed-vent system, except as provided in 40 CFR 63.162(b). Operate the system as specified in 40 CFR 63.166(b). Subpart H.
62	[40 CFR 63.167]	Open-ended valves or lines: Equip with a cap, blind flange, plug, or a second valve, except as provided in 40 CFR 63.162(b) and 40 CFR 63.167(d) and (e). Ensure that the cap, blind flange, plug or second valve seals the open end at all times except during operations requiring process fluid flow through the open-ended valve or line, or during maintenance or repair. Operate each open-ended valve or line equipped with a second valve in a manner such that the valve on the process fluid end is closed before the second valve is closed. Subpart H.
63	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase I): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified
64	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase II): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified

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65	[40 CFR 63.168(d)(1)]	Valves in gas/vapor service or light liquid service (Phase III, 2 percent or greater leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly, as specified in 40 CFR 63.180(b); or implement a quality improvement program for valves that complies with the requirements of 40 CFR 63.175 and monitor quarterly. If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). If electing to implement a quality improvement program, follow the procedures in 40 CFR 63.175. Subpart H. [40 CFR 63.168(d)(1)] Which Months: All Year Statistical Basis: None specified
66	[40 CFR 63.168(d)(2)]	Valves in gas/vapor service or light liquid service (Phase III, less than 2 percent leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Permittee may elect to comply with the alternate standards in 40 CFR 63.168(d)(3) and (d)(4). Subpart H. [40 CFR 63.168(d)(2)] Which Months: All Year Statistical Basis: None specified
67	[40 CFR 63.168(e)(1)]	Valves in gas/vapor service or light liquid service: Determine percent leaking valves using the equation in 40 CFR 63.168(e)(1). Subpart H. [40 CFR 63.168(e)(1)]
68	[40 CFR 63.168(f)(3)]	Valves in gas/vapor service or light liquid service (after leak repair): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within three months (at least) after repair to determine whether the valve has resumed leaking. Subpart H. [40 CFR 63.168(f)(3)] Which Months: All Year Statistical Basis: None specified
69	[40 CFR 63.168(f)]	Valves in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.168(f)]
70	[40 CFR 63.168(h)(1)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the valve is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.168(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(1)]
71	[40 CFR 63.168(h)(2)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the valves as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(2)] Which Months: All Year Statistical Basis: None specified
72	[40 CFR 63.168(i)(1)]	Valves in gas/vapor service or light liquid service (difficult-to-monitor): Demonstrate that the valve cannot be monitored without elevating the monitoring personnel more than 2 meters above a support surface or it is not accessible at anytime in a safe manner. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (d). Subpart H. [40 CFR 63.168(i)(1)]
73	[40 CFR 63.168(i)(3)]	Valves in gas/vapor service or light liquid service (difficult-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Maintain a written plan that requires monitoring of the valves at least once per calendar year. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (d). Subpart H. [40 CFR 63.168(i)(3)] Which Months: All Year Statistical Basis: None specified

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74	[40 CFR 63.169(a)]	Pumps, valves, connectors, and agitators in heavy liquid service; instrumentation systems; and pressure relief devices in liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) if evidence of a potential leak to the atmosphere is found by visible, audible, olfactory, or any other detection method. If a reading of 10,000 ppm for agitators, 5,000 ppm for pumps handling polymerizing monomers, 2,000 ppm for all other pumps (including pumps in food/medical service), or 500 ppm for valves, connectors, instrumentation systems, and pressure relief devices, or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.169(c). Subpart H. [40 CFR 63.169(a)] Which Months: All Year Statistical Basis: None specified
75	[40 CFR 63.169(c)]	Pumps, valves, connectors, and agitators in heavy liquid service; instrumentation systems; and pressure relief devices in liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.169(c)]
76	[40 CFR 63.170]	Surge control vessels and bottoms receivers: Equip with a closed-vent system that routes the organic vapors vented from the surge control vessel or bottoms receiver back to the process or to a control device that complies with the requirements of 40 CFR 63.172, except as provided in 40 CFR 63.162(b), or comply with the requirements of 40 CFR 63.119(b) or (c), if surge control vessel or bottoms receiver is not routed back to the process and meets the conditions specified in 40 CFR 63 Subpart H Table 2 or Table 3. Subpart H.
77	[40 CFR 63.172(f)(1)(i)]	Closed-vent system (hard-piping): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(1)(i)] Which Months: All Year Statistical Basis: None specified
78	[40 CFR 63.172(f)(1)(ii)]	Closed-vent system (hard-piping): Presence of a leak monitored by visual, audible, and/or olfactory annually. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(1)(ii)] Which Months: All Year Statistical Basis: None specified
79	[40 CFR 63.172(f)(2)(i)]	Closed-vent system (duct work): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(2)(i)] Which Months: All Year Statistical Basis: None specified
80	[40 CFR 63.172(f)(2)(ii)]	Closed-vent system (duct work): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(2)(ii)] Which Months: All Year Statistical Basis: None specified
81	[40 CFR 63.172(h)]	Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.172(i). Subpart H. [40 CFR 63.172(h)]
82	[40 CFR 63.172(j)(1)]	Closed-vent system (bypass lines): Flow monitored by flow indicator once every 15 minutes. Install flow indicator at the entrance to any bypass line. Subpart H. [40 CFR 63.172(j)(1)] Which Months: All Year Statistical Basis: None specified

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83	[40 CFR 63.172(j)(1)]	Closed-vent system (bypass lines): Flow recordkeeping by electronic or hard copy once every 15 minutes. Generate records as specified in 40 CFR 63.118(a)(3). Subpart H. [40 CFR 63.172(j)(1)]
84	[40 CFR 63.172(j)(2)]	Closed-vent system (bypass lines): Seal or closure mechanism monitored by visual inspection/determination monthly to ensure the valve is maintained in the non-diverting position and the vent stream is not diverted through the bypass line. Subpart H. [40 CFR 63.172(j)(2)] Which Months: All Year Statistical Basis: None specified
85	[40 CFR 63.172(j)(2)]	Closed-vent system (bypass lines): Secure the bypass line valve in the non-diverting position with a car-seal or a lock-and-key type configuration. Subpart H. [40 CFR 63.172(j)(2)]
86	[40 CFR 63.172(k)(1)]	Closed-vent system (unsafe-to-inspect): Demonstrate that the equipment is unsafe to inspect because inspecting personnel would be exposed to an imminent or potential dangers as a consequence of complying with 40 CFR 63.172(f)(1) or (f)(2). Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(k)(1)]
87	[40 CFR 63.172(k)(2)]	Closed-vent system (unsafe-to-inspect): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires inspection of the equipment as frequently as practicable during safe-to-inspect times, but not more frequently than annually. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(k)(2)] Which Months: All Year Statistical Basis: None specified
88	[40 CFR 63.172(l)(1)]	Closed-vent system (difficult-to-inspect): Demonstrate that the equipment cannot be inspected without elevating the inspecting personnel more than 2 meters above a support surface. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(l)(1)]
89	[40 CFR 63.172(l)(2)]	Closed-vent system (difficult-to-inspect): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once every five years. Maintain a written plan that requires inspection of the equipment at least once every five years. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(l)(2)] Which Months: All Year Statistical Basis: None specified
90	[40 CFR 63.172(m)]	Ensure that the closed-vent system or control device is operating whenever organic HAP emissions are vented to the closed-vent system or control device. Subpart H. [40 CFR 63.172(m)]
91	[40 CFR 63.173(a)]	Agitators in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.173(c). Subpart H. [40 CFR 63.173(a)] Which Months: All Year Statistical Basis: None specified
92	[40 CFR 63.173(b)]	Agitators in gas/vapor service or light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar) for indications of liquids dripping from the agitator. If there are indications of liquids dripping from the agitator, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.173(c). Subpart H. [40 CFR 63.173(b)] Which Months: All Year Statistical Basis: None specified
93	[40 CFR 63.173(c)]	Agitators in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.173(c)]

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94	[40 CFR 63.173(d)(1)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the agitator stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(1)]
95	[40 CFR 63.173(d)(2)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid organic HAP service. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(2)]
96	[40 CFR 63.173(d)(3)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(3)]
97	[40 CFR 63.173(d)(4)]	Agitators in gas/vapor service or light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the agitator seal. If there are indications of liquid dripping from the agitator seal at the time of the weekly inspection, monitor the agitator as specified in 40 CFR 63.180(b) to determine the presence of organic HAP in the barrier fluid. If an instrument reading of 10,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.173(d)(6). Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(4)] Which Months: All Year Statistical Basis: None specified
98	[40 CFR 63.173(d)(6)(i)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(6)(i)]
99	[40 CFR 63.173(d)(6)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(6)]
100	[40 CFR 63.173(d)]	Agitators in gas/vapor service or light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the agitator is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.173(d)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.173(d)(6). Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)] Which Months: All Year Statistical Basis: None specified
101	[40 CFR 63.173(h)(1)]	Agitators in gas/vapor service or light liquid service (difficult to monitor): Demonstrate that the agitator cannot be monitored without elevating the monitoring personnel more than two meters above a support surface or it is not accessible at anytime in a safe manner. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(h)(1)]

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102	[40 CFR 63.173(h)(3)]	Agitators in gas/vapor service or light liquid service (difficult-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Maintain a written plan that requires monitoring of the agitator at least once per calendar year. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(h)(3)] Which Months: All Year Statistical Basis: None specified
103	[40 CFR 63.173(j)(1)]	Agitators in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the agitator is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.173(a) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(j)(1)]
104	[40 CFR 63.173(j)(2)]	Agitators in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the agitator as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(j)(2)] Which Months: All Year Statistical Basis: None specified
105	[40 CFR 63.174(b)(1)]	Connectors in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within 12 months after the compliance date, except as provided in 40 CFR 63.174(f) through (h). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(b)(1)] Which Months: All Year Statistical Basis: None specified
106	[40 CFR 63.174(b)(2)]	Connectors in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within the first 12 months after initial startup or by no later than 12 months after the date of promulgation of a specific subpart that references 40 CFR 63 Subpart H, whichever is later, except as specified in 40 CFR 63.174(f) through (h). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(b)(2)] Which Months: All Year Statistical Basis: None specified
107	[40 CFR 63.174(b)(3)(i)]	Connectors in gas/vapor service or light liquid service (0.5% or greater leaking): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Subpart H. [40 CFR 63.174(b)(3)(i)] Which Months: All Year Statistical Basis: None specified
108	[40 CFR 63.174(b)(3)(ii)]	Connectors in gas/vapor service or light liquid service (less than 0.5% leaking): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once every two years. Subpart H. [40 CFR 63.174(b)(3)(ii)] Which Months: All Year Statistical Basis: None specified
109	[40 CFR 63.174(c)(1)(i)]	Connectors in gas/vapor service or light liquid service (opened or otherwise had the seal broken): Presence of a leak monitored by 40 CFR 60, Appendix A, Method 21 within three months after being returned to organic HAP service or when it is reconnected. If monitoring detects a leak, repair according to the provisions of 40 CFR 63.174(d), as specified, except as provided in 40 CFR 63.174(c)(1)(ii). Subpart H. [40 CFR 63.174(c)(1)(i)] Which Months: All Year Statistical Basis: None specified
110	[40 CFR 63.174(c)(2)(i)]	Connectors in gas/vapor service or light liquid service (2 inches or less in nominal diameter): Comply with the requirements of 40 CFR 63.169. Subpart H. [40 CFR 63.174(c)(2)(i)]

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111	[40 CFR 63.174(c)(2)(ii)]	Connectors in gas/vapor service or light liquid service (2 inches or less in nominal diameter): Organic HAP monitored by technically sound method within three months after being returned to organic HAP service after having been opened or otherwise had the seal broken. If monitoring detects a leak, implement repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(c)(2)(ii)] Which Months: All Year Statistical Basis: None specified
112	[40 CFR 63.174(d)]	Connectors in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171 and 63.174(g). Subpart H. [40 CFR 63.174(d)]
113	[40 CFR 63.174(f)(1)]	Connectors in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the connector is unsafe to monitor because personnel would be exposed to an immediate danger as a result of complying with 40 CFR 63.174(a) through (c). Comply with this requirement instead of the requirements in 40 CFR 63.174(a). Subpart H. [40 CFR 63.174(f)(1)]
114	[40 CFR 63.174(f)(2)]	Connectors in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of connectors as frequently as practicable during safe to monitor times, but not more frequently than the periodic schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.174(a). Subpart H. [40 CFR 63.174(f)(2)] Which Months: All Year Statistical Basis: None specified
115	[40 CFR 63.174(g)]	Connectors in gas/vapor service or light liquid service (unsafe-to-repair): Demonstrate that repair personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.174(d). Comply with this requirement instead of the requirements in 40 CFR 63.174(a), (d), and (e). Subpart H. [40 CFR 63.174(g)]
116	[40 CFR 63.174(h)(2)]	Connectors in gas/vapor service or light liquid service (inaccessible, ceramic, or ceramic-lined): Make a first attempt at repair within 5 days after leak is detected by visual, audible, olfactory or other means, and complete repairs no later than 15 calendar days after leak is detected, except as provided in 40 CFR 63.171 and 63.174(g). Comply with this requirement instead of the monitoring requirements of 40 CFR 63.174(a) and (c) and from the recordkeeping and reporting requirements of 40 CFR 63.181 and 63.182. Subpart H. [40 CFR 63.174(h)(2)]
117	[40 CFR 63.174(i)]	Connectors in gas/vapor service or light liquid service: Calculate percent leaking connectors as specified in 40 CFR 63.174(i)(1) and (i)(2). Subpart H. [40 CFR 63.174(i)]
118	[40 CFR 63.180]	Comply with the test methods and procedures requirements provided in 40 CFR 63.180. Subpart H.
119	[40 CFR 63.181]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Maintain records as specified in 40 CFR 63.181(a) through (k). Subpart H.
120	[40 CFR 63.182(b)]	Submit Initial Notification: Due within 90 days after the date of promulgation of the subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(b)(1). Subpart H. [40 CFR 63.182(b)]
121	[40 CFR 63.182(b)]	Submit application: Due as soon as practicable before the construction or reconstruction is planned to commence (but it need not be sooner than 90 days after the date of promulgation of the subpart that references 40 CFR 63 Subpart H). Submit application for approval of construction or reconstruction required by 40 CFR 63.5(d) in lieu of the Initial Notification. Subpart H. [40 CFR 63.182(b)]
122	[40 CFR 63.182(b)]	Submit Initial Notification: Due within 120 days after the date of promulgation of the subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(b)(1). Subpart H. [40 CFR 63.182(b)]

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123	[40 CFR 63.182(c)]	Submit Notification of Compliance Status: Due within 90 days of the compliance dates specified in the 40 CFR 63 subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(c)(1) through (c)(3). Subpart H. [40 CFR 63.182(c)]
124	[40 CFR 63.182(d)]	Submit Periodic Reports: Due semiannually starting 6 months after the Notification of Compliance Status, as required in 40 CFR 63.182(c). Include the information specified in 40 CFR 63.182(d)(2) through (d)(4). Subpart H. [40 CFR 63.182(d)]
125	[40 CFR 63.2480(a)]	Comply with the requirements in 40 CFR 63 Subpart H and the requirements referenced therein, except as specified in 40 CFR 63.2480(b) and (d). Subpart FFFF. [40 CFR 63.2480(a)]
126	[40 CFR 63.2525]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Keep records of the information specified in 40 CFR 63.2525(a) through (k), as applicable. Subpart FFFF.
127	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits Class III TAPs only. MACT is not required.

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128	[40 CFR 63.2520]	Permittee shall comply with the reporting requirements of 40 CFR 63.2520, as applicable. Subpart FFFF.
129	[40 CFR 63.2525]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Keep records of the information specified in 40 CFR 63.2525(a) through (k), as applicable. Subpart FFFF.
130	[40 CFR 63.982(a)(2)]	Owners or operators of process vents shall comply with the applicable provisions of 40 CFR 63.982(b), (c)(2), and (e). Subpart SS. [40 CFR 63.982(a)(2)]
131	[40 CFR 63.990(b)]	Conduct an initial performance test according to the procedures in 40 CFR 63.997, except as specified in 40 CFR 63.997(b). Subpart SS. [40 CFR 63.990(b)]
132	[40 CFR 63.990(c)(2)]	Temperature monitored by temperature monitoring device continuously. Monitor the condenser exit (product side) temperature. Subpart SS. [40 CFR 63.990(c)(2)] Which Months: All Year Statistical Basis: None specified
133	[40 CFR 63.998]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Keep records of the information specified in 40 CFR 63.998(a) through (d), as applicable. Subpart SS.
134	[40 CFR 63.999(a)(1)(iv)]	Submit application to substitute a prior performance test or compliance assessment for an initial performance test or compliance assessment, as allowed by 40 CFR63.997(b)(1), no later than 90 days before the performance test or compliance test is required. Include information demonstrating that the prior performance test or compliance assessment was conducted using the same methods specified in 40 CFR 63.997(e) or 40 CFR 63.987(b)(3), as applicable. Also include information demonstrating that no process changes have been made since the test, or that the results of the performance test or compliance assessment reliably demonstrate compliance despite process changes. Subpart SS. [40 CFR 63.999(a)(1)(iv)]
135	[40 CFR 63.999(b)]	Submit Notification of Compliance Status: Due as specified in the referencing subpart. Include the information specified in 40 CFR 63.999(b)(1) through (b)(5), as applicable. Subpart SS. [40 CFR 63.999(b)]
136	[40 CFR 63.999(c)]	Submit Periodic Report: Due as specified in the referencing subpart. Include the information specified in 40 CFR 63.999(c)(1) through (c)(7). Subpart SS. [40 CFR 63.999(c)]

Group: PCS 0003 G-1113 Process Unit

RLP 0008 201 - G-1113 Vent

137	[40 CFR 63.999(d)(1)]	Submit request for approval to use alternatives to continuous operating parameter monitoring and recordkeeping provisions, as provided for in 40 CFR 63.996(d)(1), as specified in a referencing subpart. Include the information specified in 40 CFR 63.999(d)(1)(i) and (d)(1)(ii). Subpart SS. [40 CFR 63.999(d)(1)]
138	[40 CFR 63.999(d)(2)]	Submit request for approval to monitor a different parameter than those established in 40 CFR 63.996(c)(6) or to set unique monitoring parameters, as provided for in 40 CFR 63.996(d)(2), as specified as specified in a referencing subpart. Include the information specified in 40 CFR 63.999(d)(2)(i) through (d)(2)(iii). Subpart SS. [40 CFR 63.999(d)(2)]
139	[LAC 33:III.2149.G]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Keep records of the information specified in LAC 33:III.2149.G.1 and G.2 for each process vent contained in the batch process.
140	[LAC 33:III.501.C.6]	Chilled Methanol: Temperature recordkeeping by electronic or hard copy once every shift during operation of the scrubber. (State-Only Requirement).
141	[LAC 33:III.501.C.6]	Methanol >= 94.6 % removal efficiency by maintaining the chilled methanol flowrate and temperature as specified in this permit. (State-Only Requirement). Which Months: All Year Statistical Basis: None specified
142	[LAC 33:III.501.C.6]	Chilled Methanol: Flow rate monitored by flow rate monitoring device continuously during operation of the scrubber. (State-Only Requirement). Which Months: All Year Statistical Basis: None specified
143	[LAC 33:III.501.C.6]	Submit report: Due annually, by the 31st of March for the preceding calendar year. List the hours that the scrubber operated out of the ranges specified. Submit report to the Office of Environmental Compliance, Enforcement Division. (State-Only Requirement).
144	[LAC 33:III.501.C.6]	Inlet Chilled Methanol: Temperature <= 50 F. (State-Only Requirement). Which Months: All Year Statistical Basis: None specified
145	[LAC 33:III.501.C.6]	Chilled Methanol: Flow rate recordkeeping by electronic or hard copy once every shift during operation of the scrubber. (State-Only Requirement).
146	[LAC 33:III.501.C.6]	Chilled Methanol: Temperature monitored by temperature monitoring device continuously during operation of the scrubber. (State-Only Requirement). Which Months: All Year Statistical Basis: None specified
147	[LAC 33:III.501.C.6]	Chilled Methanol: Flow rate >= 1.5 gallons/min. (State-Only Requirement). Which Months: All Year Statistical Basis: None specified
148	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Compliance with all applicable requirements of MON 40 CFR 63 Subpart FFFF is determined as MACT. This source is a Group 2 batch process vent which requires no additional controls according to the MON.

PCS 0003 G-1113 Process Unit - G-1113 Process Unit

Group Members: EQT 0017EQT 0042EQT 0043EQT 0058EQT 0059EQT 0060EQT 0061EQT 0062FUG 0007RLP 0008

149	[40 CFR 63.1]	All affected facilities shall comply with all applicable provisions in 40 CFR 63 Subpart A.

PCS 0003 G-1113 Process Unit - G-1113 Process Unit

150	[40 CFR 63.2435]	All affected facilities shall comply with all applicable provisions in 40 CFR 63 Subpart FFFF.
151	[40 CFR 63.980]	All affected facilities shall comply with all applicable provisions in 40 CFR 63 Subpart SS.

Group: PCS 0002 G-22 Process Unit

Group Members: EQT 0024 EQT 0025 EQT 0026 EQT 0027 EQT 0028 FUG 0003 FUG 0004 FUG 0005 FUG 0006 RLP 0006 SCN 0001 SCN 0002 SCN 0003 SCN 0004

EQT 0025 109-(G-22(11/12)) - Catalyst Sampling (G-22 Unit)

152	[LAC 33:III.501.C.6]	Hydrogen fluoride < 0.01 tons/yr Alternate Operating Scenario (SCN0002): Emissions are from the production of G-11/12 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Annual maximum
153	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 31.20 lb/hr Alternate Operating Scenario (SCN0002): Emissions are from the production of G-11/12 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly maximum
154	[LAC 33:III.501.C.6]	Hydrogen fluoride < 0.01 lb/hr Alternate Operating Scenario (SCN0002): Emissions are from the production of G-11/12 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly average
155	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits Class III TAPs only. MACT is not required.

EQT 0026 109-(G-22(113/114)) - Catalyst Sampling (G-22 Unit)

156	[LAC 33:III.501.C.6]	Hydrogen fluoride < 0.01 lb/hr Alternate Operating Scenario (SCN0004): Emissions are from the production of G-113/114 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly average
157	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 31.20 lb/hr Alternate Operating Scenario (SCN0004): Emissions are from the production of G-113/114 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly maximum
158	[LAC 33:III.501.C.6]	Hydrogen fluoride < 0.01 tons/yr Alternate Operating Scenario (SCN0004): Emissions are from the production of G-113/114 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Annual maximum
159	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits Class III TAPs only. MACT is not required.

EQT 0027 109-(G-22(143a)) - Catalyst Sampling (G-22 Unit)

Group: PCS 0002 G-22 Process Unit

EQT 0027 109-(G-22(143a)) - Catalyst Sampling (G-22 Unit)

160	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 0.01 tons/yr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Annual maximum
161	[LAC 33:III.501.C.6]	Hydrogen fluoride < 0.01 lb/hr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly average
162	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 31.20 lb/hr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly maximum
163	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits Class III TAPs only. MACT is not required.

EQT 0028 109-(G-22(22)) - Catalyst Sampling (G-22 Unit)

164	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 0.01 lb/hr Alternate Operating Scenario (SCN0001): Emissions are from the production of G-22 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly average
165	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 0.05 tons/yr Alternate Operating Scenario (SCN0001): Emissions are from the production of G-22 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Annual maximum
166	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 31.20 lb/hr Alternate Operating Scenario (SCN0001): Emissions are from the production of G-22 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly maximum
167	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Emits Class III TAPs only. MACT is not required.

FUG 0003 104 - G-22 Unit Fugitive Emissions (G-22 Unit)

168	[40 CFR 63.162(c)]	Identify each piece of equipment in a process unit such that it can be distinguished readily from equipment that is not subject to 40 CFR 63 Subpart H. Subpart H. [40 CFR 63.162(c)]
169	[40 CFR 63.162(f)]	Clearly identify leaking equipment, for leaking equipment detected as specified in 40 CFR 63.163, 40 CFR 63.164, 40 CFR 63.168, 40 CFR 63.169, and 40 CFR 63.172 through 63.174. The identification may be removed after the equipment is repaired, except for valves or for connectors subject to 40 CFR 63.174(c)(1)(i). The identification on a valve may be removed after it has been monitored as specified in 40 CFR 63.168(f)(3) and 63.175(e)(i)(D), and no leak has been detected during the follow-up monitoring. If electing to comply using the provisions of 40 CFR 63.174(c)(1)(i), the identification on a connector may be removed after it is monitored as specified in 40 CFR 63.174(c)(1)(i) and no leak is detected during that monitoring. Subpart H. [40 CFR 63.162(f)]

Group: PCS 0002 G-22 Process Unit

FUG 0003 104 - G-22 Unit Fugitive Emissions (G-22 Unit)

170	[40 CFR 63.163(b)(1)]	Pumps in light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, except as provided in 40 CFR 63.162(b) and 63.163(e) through (j). If a reading of 10,000 ppm (phase I); 5,000 ppm (phase II); or 5,000 ppm (phase III, pumps handling polymerizing monomers), 2,000 ppm (phase III, pumps in food/medical service), or 1,000 ppm (phase III, all other pumps) or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(1)] Which Months: All Year Statistical Basis: None specified
171	[40 CFR 63.163(b)(3)]	Pumps in light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquids dripping from the pump seal, a leak is detected. If a leak is detected, initiate the repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(3)] Which Months: All Year Statistical Basis: None specified
172	[40 CFR 63.163(c)]	Pumps in light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.163(c)(3) and 40 CFR 63.171. Subpart H. [40 CFR 63.163(c)]
173	[40 CFR 63.163(d)(2)]	Pumps in light liquid service: Implement a quality improvement program for pumps that complies with the requirements of 40 CFR 63.176, if, in Phase III, calculated on a 6-month rolling average, the greater of either 10 percent of the pumps in a process unit or three pumps in a process unit leak. Subpart H. [40 CFR 63.163(d)(2)]
174	[40 CFR 63.163(d)(4)]	Pumps in light liquid service: Determine percent leaking pumps using the equation in 40 CFR 63.163(d)(4). Subpart H. [40 CFR 63.163(d)(4)]
175	[40 CFR 63.163(e)(1)]	Pumps in light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the pump stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(1)]
176	[40 CFR 63.163(e)(2)]	Pumps in light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid service. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(2)]
177	[40 CFR 63.163(e)(3)]	Pumps in light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(3)]
178	[40 CFR 63.163(e)(4)]	Pumps in light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquid dripping from the pump seal at the time of the weekly inspection, monitor the pump as specified in 40 CFR 63.180(b) to determine if there is a leak of organic HAP in the barrier fluid. If an instrument reading of 1,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(4)] Which Months: All Year Statistical Basis: None specified
179	[40 CFR 63.163(e)(6)(i)]	Pumps in light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)(i)]

Group: PCS 0002 G-22 Process Unit

FUG 0003 104 - G-22 Unit Fugitive Emissions (G-22 Unit)

180	[40 CFR 63.163(e)(6)]	Pumps in light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)]
181	[40 CFR 63.163(e)]	Pumps in light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the pump is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.163(e)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)] Which Months: All Year Statistical Basis: None specified
182	[40 CFR 63.163(j)(1)]	Pumps in light liquid service (unsafe-to-monitor): Determine that the pump is unsafe-to-monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.163(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(1)]
183	[40 CFR 63.163(j)(2)]	Pumps in light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the pump as frequently as practicable during safe-to-monitor times but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(2)] Which Months: All Year Statistical Basis: None specified
184	[40 CFR 63.164(a)]	Compressors: Equip with a seal system that includes a barrier fluid system and that prevents leakage of process fluid to the atmosphere, except as provided in 40 CFR 63.162(b) and 40 CFR 63.164(h) and (i). Subpart H. [40 CFR 63.164(a)]
185	[40 CFR 63.164(b)]	Compressors: Operate the seal system with the barrier fluid at a pressure that is greater than the compressor stuffing box pressure; or equip with a barrier fluid system degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid directly into a process stream. Subpart H. [40 CFR 63.164(b)]
186	[40 CFR 63.164(c)]	Compressors: Ensure that the barrier fluid is not in light liquid service. Subpart H. [40 CFR 63.164(c)]
187	[40 CFR 63.164(d)]	Compressors: Equip each barrier fluid system as described in 40 CFR 63.164(a) through (c) with a sensor that will detect failure of the seal system, barrier fluid system, or both. Subpart H. [40 CFR 63.164(d)]
188	[40 CFR 63.164(e)(2)]	Compressors (sensor): Determine, based on design considerations and operating experience, a criterion that indicates failure of the seal system, the barrier fluid system, or both. Subpart H. [40 CFR 63.164(e)(2)]
189	[40 CFR 63.164(g)]	Compressors: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.164(g)]
190	[40 CFR 63.164(i)(2)]	Compressors (no detectable emissions): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially and annually, and at other times requested by DEQ. Comply with this requirement instead of the requirements in 40 CFR 63.164(a) through (h). Subpart H. [40 CFR 63.164(i)(2)] Which Months: All Year Statistical Basis: None specified

Group: PCS 0002 G-22 Process Unit

FUG 0003 104 - G-22 Unit Fugitive Emissions (G-22 Unit)

191	[40 CFR 63.164]	Compressors (sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an alarm, unless the compressor is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criterion determined under 40 CFR 63.164(e)(2), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.164(g). Subpart H. Which Months: All Year Statistical Basis: None specified
192	[40 CFR 63.165(a)]	Pressure relief device in gas/vapor service: Organic HAP < 500 ppm above background except during pressure releases, as determined by the method specified in 63.180(c). Subpart H. [40 CFR 63.165(a)] Which Months: All Year Statistical Basis: None specified
193	[40 CFR 63.165(b)(1)]	Pressure relief devices in gas/vapor service: After each pressure release, return to a condition indicated by an instrument reading of less than 500 ppm above background, as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.165(b)(1)]
194	[40 CFR 63.165(b)(2)]	Pressure relief devices in gas/vapor service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) after the pressure release and being returned to organic HAP service, to confirm the condition indicated by an instrument reading of less than 500 ppm above background, as measured by the method specified in 40 CFR 63.180(c). Subpart H. [40 CFR 63.165(b)(2)] Which Months: All Year Statistical Basis: None specified
195	[40 CFR 63.165(d)(2)]	Pressure relief devices in gas/vapor service (rupture disk): After each pressure release, install a new rupture disk upstream of the pressure relief device as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.165(a) and (b). Subpart H. [40 CFR 63.165(d)(2)]
196	[40 CFR 63.166]	Sampling connection systems: Equip with a closed-purge, closed-loop, or closed-vent system, except as provided in 40 CFR 63.162(b). Operate the system as specified in 40 CFR 63.166(b). Subpart H.
197	[40 CFR 63.167]	Open-ended valves or lines: Equip with a cap, blind flange, plug, or a second valve, except as provided in 40 CFR 63.162(b) and 40 CFR 63.167(d) and (e). Ensure that the cap, blind flange, plug or second valve seals the open end at all times except during operations requiring process fluid flow through the open-ended valve or line, or during maintenance or repair. Operate each open-ended valve or line equipped with a second valve in a manner such that the valve on the process fluid end is closed before the second valve is closed. Subpart H.
198	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase I): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified
199	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase II): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified

Group: PCS 0002 G-22 Process Unit

FUG 0003 104 - G-22 Unit Fugitive Emissions (G-22 Unit)

200	[40 CFR 63.168(d)(1)]	Valves in gas/vapor service or light liquid service (Phase III, 2 percent or greater leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly, as specified in 40 CFR 63.180(b); or implement a quality improvement program for valves that complies with the requirements of 40 CFR 63.175 and monitor quarterly. If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). If electing to implement a quality improvement program, follow the procedures in 40 CFR 63.175. Subpart H. [40 CFR 63.168(d)(1)] Which Months: All Year Statistical Basis: None specified
201	[40 CFR 63.168(d)(2)]	Valves in gas/vapor service or light liquid service (Phase III, less than 2 percent leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Permittee may elect to comply with the alternate standards in 40 CFR 63.168(d)(3) and (d)(4). Subpart H. [40 CFR 63.168(d)(2)] Which Months: All Year Statistical Basis: None specified
202	[40 CFR 63.168(e)(1)]	Valves in gas/vapor service or light liquid service: Determine percent leaking valves using the equation in 40 CFR 63.168(e)(1). Subpart H. [40 CFR 63.168(e)(1)]
203	[40 CFR 63.168(f)(3)]	Valves in gas/vapor service or light liquid service (after leak repair): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within three months (at least) after repair to determine whether the valve has resumed leaking. Subpart H. [40 CFR 63.168(f)(3)] Which Months: All Year Statistical Basis: None specified
204	[40 CFR 63.168(f)]	Valves in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.168(f)]
205	[40 CFR 63.168(h)(1)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the valve is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.168(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(1)]
206	[40 CFR 63.168(h)(2)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the valves as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(2)] Which Months: All Year Statistical Basis: None specified
207	[40 CFR 63.168(i)(1)]	Valves in gas/vapor service or light liquid service (difficult-to-monitor): Demonstrate that the valve cannot be monitored without elevating the monitoring personnel more than 2 meters above a support surface or it is not accessible at anytime in a safe manner. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (d). Subpart H. [40 CFR 63.168(i)(1)]
208	[40 CFR 63.168(i)(3)]	Valves in gas/vapor service or light liquid service (difficult-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Maintain a written plan that requires monitoring of the valves at least once per calendar year. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (d). Subpart H. [40 CFR 63.168(i)(3)] Which Months: All Year Statistical Basis: None specified

Group: PCS 0002 G-22 Process Unit

FUG 0003 104 - G-22 Unit Fugitive Emissions (G-22 Unit)

209	[40 CFR 63.169(a)]	Pumps, valves, connectors, and agitators in heavy liquid service; instrumentation systems; and pressure relief devices in liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) if evidence of a potential leak to the atmosphere is found by visible, audible, olfactory, or any other detection method. If a reading of 10,000 ppm for agitators, 5,000 ppm for pumps handling polymerizing monomers, 2,000 ppm for all other pumps (including pumps in food/medical service), or 500 ppm for valves, connectors, instrumentation systems, and pressure relief devices, or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.169(c). Subpart H. [40 CFR 63.169(a)] Which Months: All Year Statistical Basis: None specified
210	[40 CFR 63.169(c)]	Pumps, valves, connectors, and agitators in heavy liquid service; instrumentation systems; and pressure relief devices in liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.169(c)]
211	[40 CFR 63.170]	Surge control vessels and bottoms receivers: Equip with a closed-vent system that routes the organic vapors vented from the surge control vessel or bottoms receiver back to the process or to a control device that complies with the requirements of 40 CFR 63.172, except as provided in 40 CFR 63.162(b), or comply with the requirements of 40 CFR 63.119(b) or (c), if surge control vessel or bottoms receiver is not routed back to the process and meets the conditions specified in 40 CFR 63 Subpart H Table 2 or Table 3. Subpart H.
212	[40 CFR 63.172(f)(1)(i)]	Closed-vent system (hard-piping): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(1)(i)] Which Months: All Year Statistical Basis: None specified
213	[40 CFR 63.172(f)(1)(ii)]	Closed-vent system (hard-piping): Presence of a leak monitored by visual, audible, and/or olfactory annually. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(1)(ii)] Which Months: All Year Statistical Basis: None specified
214	[40 CFR 63.172(f)(2)(i)]	Closed-vent system (duct work): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(2)(i)] Which Months: All Year Statistical Basis: None specified
215	[40 CFR 63.172(f)(2)(ii)]	Closed-vent system (duct work): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(2)(ii)] Which Months: All Year Statistical Basis: None specified
216	[40 CFR 63.172(h)]	Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.172(i). Subpart H. [40 CFR 63.172(h)]
217	[40 CFR 63.172(j)(1)]	Closed-vent system (bypass lines): Flow monitored by flow indicator once every 15 minutes. Install flow indicator at the entrance to any bypass line. Subpart H. [40 CFR 63.172(j)(1)] Which Months: All Year Statistical Basis: None specified

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218	[40 CFR 63.172(j)(1)]	Closed-vent system (bypass lines): Flow recordkeeping by electronic or hard copy once every 15 minutes. Generate records as specified in 40 CFR 63.118(a)(3). Subpart H. [40 CFR 63.172(j)(1)]
219	[40 CFR 63.172(j)(2)]	Closed-vent system (bypass lines): Seal or closure mechanism monitored by visual inspection/determination monthly to ensure the valve is maintained in the non-diverting position and the vent stream is not diverted through the bypass line. Subpart H. [40 CFR 63.172(j)(2)] Which Months: All Year Statistical Basis: None specified
220	[40 CFR 63.172(j)(2)]	Closed-vent system (bypass lines): Secure the bypass line valve in the non-diverting position with a car-seal or a lock-and-key type configuration. Subpart H. [40 CFR 63.172(j)(2)]
221	[40 CFR 63.172(k)(1)]	Closed-vent system (unsafe-to-inspect): Demonstrate that the equipment is unsafe to inspect because inspecting personnel would be exposed to an imminent or potential dangers as a consequence of complying with 40 CFR 63.172(f)(1) or (f)(2). Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(k)(1)]
222	[40 CFR 63.172(k)(2)]	Closed-vent system (unsafe-to-inspect): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires inspection of the equipment as frequently as practicable during safe-to-inspect times, but not more frequently than annually. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(k)(2)] Which Months: All Year Statistical Basis: None specified
223	[40 CFR 63.172(l)(1)]	Closed-vent system (difficult-to-inspect): Demonstrate that the equipment cannot be inspected without elevating the inspecting personnel more than 2 meters above a support surface. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(l)(1)]
224	[40 CFR 63.172(l)(2)]	Closed-vent system (difficult-to-inspect): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once every five years. Maintain a written plan that requires inspection of the equipment at least once every five years. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(l)(2)] Which Months: All Year Statistical Basis: None specified
225	[40 CFR 63.172(m)]	Ensure that the closed-vent system or control device is operating whenever organic HAP emissions are vented to the closed-vent system or control device. Subpart H. [40 CFR 63.172(m)]
226	[40 CFR 63.173(a)]	Agitators in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.173(c). Subpart H. [40 CFR 63.173(a)] Which Months: All Year Statistical Basis: None specified
227	[40 CFR 63.173(b)]	Agitators in gas/vapor service or light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar) for indications of liquids dripping from the agitator. If there are indications of liquids dripping from the agitator, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.173(c). Subpart H. [40 CFR 63.173(b)] Which Months: All Year Statistical Basis: None specified
228	[40 CFR 63.173(c)]	Agitators in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.173(c)]

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229	[40 CFR 63.173(d)(1)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the agitator stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(1)]
230	[40 CFR 63.173(d)(2)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid organic HAP service. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(2)]
231	[40 CFR 63.173(d)(3)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(3)]
232	[40 CFR 63.173(d)(4)]	Agitators in gas/vapor service or light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the agitator seal. If there are indications of liquid dripping from the agitator seal at the time of the weekly inspection, monitor the agitator as specified in 40 CFR 63.180(b) to determine the presence of organic HAP in the barrier fluid. If an instrument reading of 10,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.173(d)(6). Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(4)] Which Months: All Year Statistical Basis: None specified
233	[40 CFR 63.173(d)(6)(i)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(6)(i)]
234	[40 CFR 63.173(d)(6)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(6)]
235	[40 CFR 63.173(d)]	Agitators in gas/vapor service or light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the agitator is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.173(d)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.173(d)(6). Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)] Which Months: All Year Statistical Basis: None specified
236	[40 CFR 63.173(h)(1)]	Agitators in gas/vapor service or light liquid service (difficult to monitor): Demonstrate that the agitator cannot be monitored without elevating the monitoring personnel more than two meters above a support surface or it is not accessible at anytime in a safe manner. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(h)(1)]

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237	[40 CFR 63.173(h)(3)]	Agitators in gas/vapor service or light liquid service (difficult-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Maintain a written plan that requires monitoring of the agitator at least once per calendar year. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(h)(3)] Which Months: All Year Statistical Basis: None specified
238	[40 CFR 63.173(j)(1)]	Agitators in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the agitator is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.173(a) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(j)(1)]
239	[40 CFR 63.173(j)(2)]	Agitators in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the agitator as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(j)(2)] Which Months: All Year Statistical Basis: None specified
240	[40 CFR 63.174(b)(1)]	Connectors in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within 12 months after the compliance date, except as provided in 40 CFR 63.174(f) through (h). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(b)(1)] Which Months: All Year Statistical Basis: None specified
241	[40 CFR 63.174(b)(2)]	Connectors in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within the first 12 months after initial startup or by no later than 12 months after the date of promulgation of a specific subpart that references 40 CFR 63 Subpart H, whichever is later, except as specified in 40 CFR 63.174(f) through (h). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(b)(2)] Which Months: All Year Statistical Basis: None specified
242	[40 CFR 63.174(b)(3)(i)]	Connectors in gas/vapor service or light liquid service (0.5% or greater leaking): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Subpart H. [40 CFR 63.174(b)(3)(i)] Which Months: All Year Statistical Basis: None specified
243	[40 CFR 63.174(b)(3)(ii)]	Connectors in gas/vapor service or light liquid service (less than 0.5% leaking): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once every two years. Subpart H. [40 CFR 63.174(b)(3)(ii)] Which Months: All Year Statistical Basis: None specified
244	[40 CFR 63.174(c)(1)(i)]	Connectors in gas/vapor service or light liquid service (opened or otherwise had the seal broken): Presence of a leak monitored by 40 CFR 60, Appendix A, Method 21 within three months after being returned to organic HAP service or when it is reconnected. If monitoring detects a leak, repair according to the provisions of 40 CFR 63.174(d), as specified, except as provided in 40 CFR 63.174(c)(1)(ii). Subpart H. [40 CFR 63.174(c)(1)(i)] Which Months: All Year Statistical Basis: None specified
245	[40 CFR 63.174(c)(2)(i)]	Connectors in gas/vapor service or light liquid service (2 inches or less in nominal diameter): Comply with the requirements of 40 CFR 63.169. Subpart H. [40 CFR 63.174(c)(2)(i)]

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246	[40 CFR 63.174(c)(2)(ii)]	Connectors in gas/vapor service or light liquid service (2 inches or less in nominal diameter): Organic HAP monitored by technically sound method within three months after being returned to organic HAP service after having been opened or otherwise had the seal broken. If monitoring detects a leak, implement repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(c)(2)(ii)] Which Months: All Year Statistical Basis: None specified
247	[40 CFR 63.174(d)]	Connectors in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171 and 63.174(g). Subpart H. [40 CFR 63.174(d)]
248	[40 CFR 63.174(f)(1)]	Connectors in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the connector is unsafe to monitor because personnel would be exposed to an immediate danger as a result of complying with 40 CFR 63.174(a) through (c). Comply with this requirement instead of the requirements in 40 CFR 63.174(a). Subpart H. [40 CFR 63.174(f)(1)]
249	[40 CFR 63.174(f)(2)]	Connectors in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of connectors as frequently as practicable during safe to monitor times, but not more frequently than the periodic schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.174(a). Subpart H. [40 CFR 63.174(f)(2)] Which Months: All Year Statistical Basis: None specified
250	[40 CFR 63.174(g)]	Connectors in gas/vapor service or light liquid service (unsafe-to-repair): Demonstrate that repair personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.174(d). Comply with this requirement instead of the requirements in 40 CFR 63.174(a), (d), and (e). Subpart H. [40 CFR 63.174(g)]
251	[40 CFR 63.174(h)(2)]	Connectors in gas/vapor service or light liquid service (inaccessible, ceramic, or ceramic-lined): Make a first attempt at repair within 5 days after leak is detected by visual, audible, olfactory or other means, and complete repairs no later than 15 calendar days after leak is detected, except as provided in 40 CFR 63.171 and 63.174(g). Comply with this requirement instead of the monitoring requirements of 40 CFR 63.174(a) and (c) and from the recordkeeping and reporting requirements of 40 CFR 63.181 and 63.182. Subpart H. [40 CFR 63.174(h)(2)]
252	[40 CFR 63.174(i)]	Connectors in gas/vapor service or light liquid service: Calculate percent leaking connectors as specified in 40 CFR 63.174(i)(1) and (i)(2). Subpart H. [40 CFR 63.174(i)]
253	[40 CFR 63.180]	Comply with the test methods and procedures requirements provided in 40 CFR 63.180. Subpart H.
254	[40 CFR 63.181]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Maintain records as specified in 40 CFR 63.181(a) through (k). Subpart H.
255	[40 CFR 63.182(b)]	Submit Initial Notification: Due within 120 days after the date of promulgation of the subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(b)(1). Subpart H. [40 CFR 63.182(b)]
256	[40 CFR 63.182(c)]	Submit Notification of Compliance Status: Due within 90 days of the compliance dates specified in the 40 CFR 63 subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(c)(1) through (c)(3). Subpart H. [40 CFR 63.182(c)]
257	[40 CFR 63.182(d)]	Submit Periodic Reports: Due semiannually starting 6 months after the Notification of Compliance Status, as required in 40 CFR 63.182(c). Include the information specified in 40 CFR 63.182(d)(2) through (d)(4). Subpart H. [40 CFR 63.182(d)]

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258	[40 CFR 63.9000(a)]	Prepare and operate at all times according to an equipment LDAR plan that describes in detail the measure that will be put in place to detect leaks and repair them in a timely fashion. Submit the plan to DEQ for comment only with the Notification of Compliance Status. (Applies only to specific components in HCl service as defined by the rule.) Subpart NNNNN. [40 CFR 63.9000(a)]
259	[40 CFR 63.9040(a)]	Demonstrate continuous compliance with 40 CFR 63 Subpart NNNNN, Table 1 and Table 2, as applicable, according to 40 CFR 63 Subpart NNNNN, Table 4 and Table 5. (Applies only to specific components in HCl service as defined by the rule.) Subpart NNNNN. [40 CFR 63.9040(a)]
260	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 3.80 tons/yr Alternate Operating Scenario (SCN0001): Emissions are from the production of G-22 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Annual maximum
261	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 0.87 lb/hr Alternate Operating Scenario (SCN0001): Emissions are from the production of G-22 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly maximum
262	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 0.87 lb/hr Alternate Operating Scenario (SCN0001): Emissions are from the production of G-22 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly average
263	[LAC 33:III.501]	Comply with 40 CFR 63 Subpart H (HON), LAC 33:III.2122, and LAC 33:III.5109 (Louisiana Non-HON MACT) by implementing the Louisiana Consolidated Fugitive Emission Program Guidelines. Compliance is achieved through compliance with 40 CFR 63 Subpart H (HON). [LAC 33:III.501, LAC 33:III.2122.A, 40 CFR 63.160]
264	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Compliance with the requirements of 40 CFR 63 Subpart H (HON) in accordance with the streamlining provisions in 40 CFR Part 70 Specific Condition No. 1 and 40 CFR 63 Subpart NNNNN for specific components in HCl service constitutes MACT.

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265	[40 CFR 63.162(c)]	Identify each piece of equipment in a process unit such that it can be distinguished readily from equipment that is not subject to 40 CFR 63 Subpart H. Subpart H. [40 CFR 63.162(c)]
266	[40 CFR 63.162(f)]	Clearly identify leaking equipment, for leaking equipment detected as specified in 40 CFR 63.163, 40 CFR 63.164, 40 CFR 63.168, 40 CFR 63.169, and 40 CFR 63.172 through 63.174. The identification may be removed after the equipment is repaired, except for valves or for connectors subject to 40 CFR 63.174(c)(1)(i). The identification on a valve may be removed after it has been monitored as specified in 40 CFR 63.168(f)(3) and 63.175(e)(i)(D), and no leak has been detected during the follow-up monitoring. If electing to comply using the provisions of 40 CFR 63.174(c)(1)(i), the identification on a connector may be removed after it is monitored as specified in 40 CFR 63.174(c)(1)(i) and no leak is detected during that monitoring. Subpart H. [40 CFR 63.162(f)]

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267	[40 CFR 63.163(b)(1)]	Pumps in light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, except as provided in 40 CFR 63.162(b) and 63.163(e) through (j). If a reading of 10,000 ppm (phase I); 5,000 ppm (phase II); or 5,000 ppm (phase III, pumps handling polymerizing monomers), 2,000 ppm (phase III, pumps in food/medical service), or 1,000 ppm (phase III, all other pumps) or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(1)] Which Months: All Year Statistical Basis: None specified
268	[40 CFR 63.163(b)(3)]	Pumps in light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquids dripping from the pump seal, a leak is detected. If a leak is detected, initiate the repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(3)] Which Months: All Year Statistical Basis: None specified
269	[40 CFR 63.163(c)]	Pumps in light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.163(c)(3) and 40 CFR 63.171. Subpart H. [40 CFR 63.163(c)]
270	[40 CFR 63.163(d)(2)]	Pumps in light liquid service: Implement a quality improvement program for pumps that complies with the requirements of 40 CFR 63.176, if, in Phase III, calculated on a 6-month rolling average, the greater of either 10 percent of the pumps in a process unit or three pumps in a process unit leak. Subpart H. [40 CFR 63.163(d)(2)]
271	[40 CFR 63.163(d)(4)]	Pumps in light liquid service: Determine percent leaking pumps using the equation in 40 CFR 63.163(d)(4). Subpart H. [40 CFR 63.163(d)(4)]
272	[40 CFR 63.163(e)(1)]	Pumps in light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the pump stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(1)]
273	[40 CFR 63.163(e)(2)]	Pumps in light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid service. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(2)]
274	[40 CFR 63.163(e)(3)]	Pumps in light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(3)]
275	[40 CFR 63.163(e)(4)]	Pumps in light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquid dripping from the pump seal at the time of the weekly inspection, monitor the pump as specified in 40 CFR 63.180(b) to determine if there is a leak of organic HAP in the barrier fluid. If an instrument reading of 1,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(4)] Which Months: All Year Statistical Basis: None specified
276	[40 CFR 63.163(e)(6)(i)]	Pumps in light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)(i)]

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277	[40 CFR 63.163(e)(6)]	Pumps in light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)]
278	[40 CFR 63.163(e)]	Pumps in light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the pump is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.163(e)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)] Which Months: All Year Statistical Basis: None specified
279	[40 CFR 63.163(j)(1)]	Pumps in light liquid service (unsafe-to-monitor): Determine that the pump is unsafe-to-monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.163(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(1)]
280	[40 CFR 63.163(j)(2)]	Pumps in light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the pump as frequently as practicable during safe-to-monitor times but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(2)] Which Months: All Year Statistical Basis: None specified
281	[40 CFR 63.164(a)]	Compressors: Equip with a seal system that includes a barrier fluid system and that prevents leakage of process fluid to the atmosphere, except as provided in 40 CFR 63.162(b) and 40 CFR 63.164(h) and (i). Subpart H. [40 CFR 63.164(a)]
282	[40 CFR 63.164(b)]	Compressors: Operate the seal system with the barrier fluid at a pressure that is greater than the compressor stuffing box pressure; or equip with a barrier fluid system degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid directly into a process stream. Subpart H. [40 CFR 63.164(b)]
283	[40 CFR 63.164(c)]	Compressors: Ensure that the barrier fluid is not in light liquid service. Subpart H. [40 CFR 63.164(c)]
284	[40 CFR 63.164(d)]	Compressors: Equip each barrier fluid system as described in 40 CFR 63.164(a) through (c) with a sensor that will detect failure of the seal system, barrier fluid system, or both. Subpart H. [40 CFR 63.164(d)]
285	[40 CFR 63.164(e)(2)]	Compressors (sensor): Determine, based on design considerations and operating experience, a criterion that indicates failure of the seal system, the barrier fluid system, or both. Subpart H. [40 CFR 63.164(e)(2)]
286	[40 CFR 63.164(g)]	Compressors: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.164(g)]
287	[40 CFR 63.164(i)(2)]	Compressors (no detectable emissions): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially and annually, and at other times requested by DEQ. Comply with this requirement instead of the requirements in 40 CFR 63.164(a) through (h). Subpart H. [40 CFR 63.164(i)(2)] Which Months: All Year Statistical Basis: None specified

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288	[40 CFR 63.164]	Compressors (sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an alarm, unless the compressor is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criterion determined under 40 CFR 63.164(e)(2), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.164(g). Subpart H. Which Months: All Year Statistical Basis: None specified
289	[40 CFR 63.165(a)]	Pressure relief device in gas/vapor service: Organic HAP < 500 ppm above background except during pressure releases, as determined by the method specified in 63.180(c). Subpart H. [40 CFR 63.165(a)] Which Months: All Year Statistical Basis: None specified
290	[40 CFR 63.165(b)(1)]	Pressure relief devices in gas/vapor service: After each pressure release, return to a condition indicated by an instrument reading of less than 500 ppm above background, as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.165(b)(1)]
291	[40 CFR 63.165(b)(2)]	Pressure relief devices in gas/vapor service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) after the pressure release and being returned to organic HAP service, to confirm the condition indicated by an instrument reading of less than 500 ppm above background, as measured by the method specified in 40 CFR 63.180(c). Subpart H. [40 CFR 63.165(b)(2)] Which Months: All Year Statistical Basis: None specified
292	[40 CFR 63.165(d)(2)]	Pressure relief devices in gas/vapor service (rupture disk): After each pressure release, install a new rupture disk upstream of the pressure relief device as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.165(a) and (b). Subpart H. [40 CFR 63.165(d)(2)]
293	[40 CFR 63.166]	Sampling connection systems: Equip with a closed-purge, closed-loop, or closed-vent system, except as provided in 40 CFR 63.162(b). Operate the system as specified in 40 CFR 63.166(b). Subpart H.
294	[40 CFR 63.167]	Open-ended valves or lines: Equip with a cap, blind flange, plug, or a second valve, except as provided in 40 CFR 63.162(b) and 40 CFR 63.167(d) and (e). Ensure that the cap, blind flange, plug or second valve seals the open end at all times except during operations requiring process fluid flow through the open-ended valve or line, or during maintenance or repair. Operate each open-ended valve or line equipped with a second valve in a manner such that the valve on the process fluid end is closed before the second valve is closed. Subpart H.
295	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase I): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified
296	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase II): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified

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297	[40 CFR 63.168(d)(1)]	Valves in gas/vapor service or light liquid service (Phase III, 2 percent or greater leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly, as specified in 40 CFR 63.180(b); or implement a quality improvement program for valves that complies with the requirements of 40 CFR 63.175 and monitor quarterly. If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). If electing to implement a quality improvement program, follow the procedures in 40 CFR 63.175. Subpart H. [40 CFR 63.168(d)(1)] Which Months: All Year Statistical Basis: None specified
298	[40 CFR 63.168(d)(2)]	Valves in gas/vapor service or light liquid service (Phase III, less than 2 percent leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Permittee may elect to comply with the alternate standards in 40 CFR 63.168(d)(3) and (d)(4). Subpart H. [40 CFR 63.168(d)(2)] Which Months: All Year Statistical Basis: None specified
299	[40 CFR 63.168(e)(1)]	Valves in gas/vapor service or light liquid service: Determine percent leaking valves using the equation in 40 CFR 63.168(e)(1). Subpart H. [40 CFR 63.168(e)(1)]
300	[40 CFR 63.168(f)(3)]	Valves in gas/vapor service or light liquid service (after leak repair): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within three months (at least) after repair to determine whether the valve has resumed leaking. Subpart H. [40 CFR 63.168(f)(3)] Which Months: All Year Statistical Basis: None specified
301	[40 CFR 63.168(f)]	Valves in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.168(f)]
302	[40 CFR 63.168(h)(1)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the valve is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.168(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(1)]
303	[40 CFR 63.168(h)(2)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the valves as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(2)] Which Months: All Year Statistical Basis: None specified
304	[40 CFR 63.168(i)(1)]	Valves in gas/vapor service or light liquid service (difficult-to-monitor): Demonstrate that the valve cannot be monitored without elevating the monitoring personnel more than 2 meters above a support surface or it is not accessible at anytime in a safe manner. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (d). Subpart H. [40 CFR 63.168(i)(1)]
305	[40 CFR 63.168(i)(3)]	Valves in gas/vapor service or light liquid service (difficult-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Maintain a written plan that requires monitoring of the valves at least once per calendar year. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (d). Subpart H. [40 CFR 63.168(i)(3)] Which Months: All Year Statistical Basis: None specified

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306	[40 CFR 63.169(a)]	Pumps, valves, connectors, and agitators in heavy liquid service; instrumentation systems; and pressure relief devices in liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) if evidence of a potential leak to the atmosphere is found by visible, audible, olfactory, or any other detection method. If a reading of 10,000 ppm for agitators, 5,000 ppm for pumps handling polymerizing monomers, 2,000 ppm for all other pumps (including pumps in food/medical service), or 500 ppm for valves, connectors, instrumentation systems, and pressure relief devices, or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.169(c). Subpart H. [40 CFR 63.169(a)] Which Months: All Year Statistical Basis: None specified
307	[40 CFR 63.169(c)]	Pumps, valves, connectors, and agitators in heavy liquid service; instrumentation systems; and pressure relief devices in liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.169(c)]
308	[40 CFR 63.170]	Surge control vessels and bottoms receivers: Equip with a closed-vent system that routes the organic vapors vented from the surge control vessel or bottoms receiver back to the process or to a control device that complies with the requirements of 40 CFR 63.172, except as provided in 40 CFR 63.162(b), or comply with the requirements of 40 CFR 63.119(b) or (c), if surge control vessel or bottoms receiver is not routed back to the process and meets the conditions specified in 40 CFR 63 Subpart H Table 2 or Table 3. Subpart H.
309	[40 CFR 63.172(f)(1)(i)]	Closed-vent system (hard-piping): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(1)(i)] Which Months: All Year Statistical Basis: None specified
310	[40 CFR 63.172(f)(1)(ii)]	Closed-vent system (hard-piping): Presence of a leak monitored by visual, audible, and/or olfactory annually. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(1)(ii)] Which Months: All Year Statistical Basis: None specified
311	[40 CFR 63.172(f)(2)(i)]	Closed-vent system (duct work): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(2)(i)] Which Months: All Year Statistical Basis: None specified
312	[40 CFR 63.172(f)(2)(ii)]	Closed-vent system (duct work): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(2)(ii)] Which Months: All Year Statistical Basis: None specified
313	[40 CFR 63.172(h)]	Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.172(i). Subpart H. [40 CFR 63.172(h)]
314	[40 CFR 63.172(j)(1)]	Closed-vent system (bypass lines): Flow recordkeeping by electronic or hard copy once every 15 minutes. Generate records as specified in 40 CFR 63.118(a)(3). Subpart H. [40 CFR 63.172(j)(1)]

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315	[40 CFR 63.172(j)(1)]	Closed-vent system (bypass lines): Flow monitored by flow indicator once every 15 minutes. Install flow indicator at the entrance to any bypass line. Subpart H. [40 CFR 63.172(j)(1)] Which Months: All Year Statistical Basis: None specified
316	[40 CFR 63.172(j)(2)]	Closed-vent system (bypass lines): Seal or closure mechanism monitored by visual inspection/determination monthly to ensure the valve is maintained in the non-diverting position and the vent stream is not diverted through the bypass line. Subpart H. [40 CFR 63.172(j)(2)] Which Months: All Year Statistical Basis: None specified
317	[40 CFR 63.172(j)(2)]	Closed-vent system (bypass lines): Secure the bypass line valve in the non-diverting position with a car-seal or a lock-and-key type configuration. Subpart H. [40 CFR 63.172(j)(2)]
318	[40 CFR 63.172(k)(1)]	Closed-vent system (unsafe-to-inspect): Demonstrate that the equipment is unsafe to inspect because inspecting personnel would be exposed to an imminent or potential dangers as a consequence of complying with 40 CFR 63.172(f)(1) or (f)(2). Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(k)(1)]
319	[40 CFR 63.172(k)(2)]	Closed-vent system (unsafe-to-inspect): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires inspection of the equipment as frequently as practicable during safe-to-inspect times, but not more frequently than annually. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(k)(2)] Which Months: All Year Statistical Basis: None specified
320	[40 CFR 63.172(l)(1)]	Closed-vent system (difficult-to-inspect): Demonstrate that the equipment cannot be inspected without elevating the inspecting personnel more than 2 meters above a support surface. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(l)(1)]
321	[40 CFR 63.172(l)(2)]	Closed-vent system (difficult-to-inspect): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once every five years. Maintain a written plan that requires inspection of the equipment at least once every five years. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(l)(2)] Which Months: All Year Statistical Basis: None specified
322	[40 CFR 63.172(m)]	Ensure that the closed-vent system or control device is operating whenever organic HAP emissions are vented to the closed-vent system or control device. Subpart H. [40 CFR 63.172(m)]
323	[40 CFR 63.173(a)]	Agitators in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.173(c). Subpart H. [40 CFR 63.173(a)] Which Months: All Year Statistical Basis: None specified
324	[40 CFR 63.173(b)]	Agitators in gas/vapor service or light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar) for indications of liquids dripping from the agitator. If there are indications of liquids dripping from the agitator, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.173(c). Subpart H. [40 CFR 63.173(b)] Which Months: All Year Statistical Basis: None specified

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325	[40 CFR 63.173(c)]	Agitators in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.173(c)]
326	[40 CFR 63.173(d)(1)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the agitator stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(1)]
327	[40 CFR 63.173(d)(2)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid organic HAP service. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(2)]
328	[40 CFR 63.173(d)(3)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(3)]
329	[40 CFR 63.173(d)(4)]	Agitators in gas/vapor service or light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the agitator seal. If there are indications of liquid dripping from the agitator seal at the time of the weekly inspection, monitor the agitator as specified in 40 CFR 63.180(b) to determine the presence of organic HAP in the barrier fluid. If an instrument reading of 10,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.173(d)(6). Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(4)] Which Months: All Year Statistical Basis: None specified
330	[40 CFR 63.173(d)(6)(i)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(6)(i)]
331	[40 CFR 63.173(d)(6)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(6)]
332	[40 CFR 63.173(d)]	Agitators in gas/vapor service or light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the agitator is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.173(d)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.173(d)(6). Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)] Which Months: All Year Statistical Basis: None specified
333	[40 CFR 63.173(h)(1)]	Agitators in gas/vapor service or light liquid service (difficult to monitor): Demonstrate that the agitator cannot be monitored without elevating the monitoring personnel more than two meters above a support surface or it is not accessible at anytime in a safe manner. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(h)(1)]

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334	[40 CFR 63.173(h)(3)]	Agitators in gas/vapor service or light liquid service (difficult-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Maintain a written plan that requires monitoring of the agitator at least once per calendar year. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(h)(3)] Which Months: All Year Statistical Basis: None specified
335	[40 CFR 63.173(j)(1)]	Agitators in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the agitator is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.173(a) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(j)(1)]
336	[40 CFR 63.173(j)(2)]	Agitators in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the agitator as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(j)(2)] Which Months: All Year Statistical Basis: None specified
337	[40 CFR 63.174(b)(1)]	Connectors in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within 12 months after the compliance date, except as provided in 40 CFR 63.174(f) through (h). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(b)(1)] Which Months: All Year Statistical Basis: None specified
338	[40 CFR 63.174(b)(2)]	Connectors in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within the first 12 months after initial startup or by no later than 12 months after the date of promulgation of a specific subpart that references 40 CFR 63 Subpart H, whichever is later, except as specified in 40 CFR 63.174(f) through (h). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(b)(2)] Which Months: All Year Statistical Basis: None specified
339	[40 CFR 63.174(b)(3)(i)]	Connectors in gas/vapor service or light liquid service (0.5% or greater leaking): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Subpart H. [40 CFR 63.174(b)(3)(i)] Which Months: All Year Statistical Basis: None specified
340	[40 CFR 63.174(b)(3)(ii)]	Connectors in gas/vapor service or light liquid service (less than 0.5% leaking): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once every two years. Subpart H. [40 CFR 63.174(b)(3)(ii)] Which Months: All Year Statistical Basis: None specified
341	[40 CFR 63.174(c)(1)(i)]	Connectors in gas/vapor service or light liquid service (opened or otherwise had the seal broken): Presence of a leak monitored by 40 CFR 60, Appendix A, Method 21 within three months after being returned to organic HAP service or when it is reconnected. If monitoring detects a leak, repair according to the provisions of 40 CFR 63.174(d), as specified, except as provided in 40 CFR 63.174(c)(1)(ii). Subpart H. [40 CFR 63.174(c)(1)(i)] Which Months: All Year Statistical Basis: None specified
342	[40 CFR 63.174(c)(2)(i)]	Connectors in gas/vapor service or light liquid service (2 inches or less in nominal diameter): Comply with the requirements of 40 CFR 63.169. Subpart H. [40 CFR 63.174(c)(2)(i)]

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343	[40 CFR 63.174(c)(2)(ii)]	Connectors in gas/vapor service or light liquid service (2 inches or less in nominal diameter): Organic HAP monitored by technically sound method within three months after being returned to organic HAP service after having been opened or otherwise had the seal broken. If monitoring detects a leak, implement repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(c)(2)(ii)] Which Months: All Year Statistical Basis: None specified
344	[40 CFR 63.174(d)]	Connectors in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171 and 63.174(g). Subpart H. [40 CFR 63.174(d)]
345	[40 CFR 63.174(f)(1)]	Connectors in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the connector is unsafe to monitor because personnel would be exposed to an immediate danger as a result of complying with 40 CFR 63.174(a) through (c). Comply with this requirement instead of the requirements in 40 CFR 63.174(a). Subpart H. [40 CFR 63.174(f)(1)]
346	[40 CFR 63.174(f)(2)]	Connectors in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of connectors as frequently as practicable during safe to monitor times, but not more frequently than the periodic schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.174(a). Subpart H. [40 CFR 63.174(f)(2)] Which Months: All Year Statistical Basis: None specified
347	[40 CFR 63.174(g)]	Connectors in gas/vapor service or light liquid service (unsafe-to-repair): Demonstrate that repair personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.174(d). Comply with this requirement instead of the requirements in 40 CFR 63.174(a), (d), and (e). Subpart H. [40 CFR 63.174(g)]
348	[40 CFR 63.174(h)(2)]	Connectors in gas/vapor service or light liquid service (inaccessible, ceramic, or ceramic-lined): Make a first attempt at repair within 5 days after leak is detected by visual, audible, olfactory or other means, and complete repairs no later than 15 calendar days after leak is detected, except as provided in 40 CFR 63.171 and 63.174(g). Comply with this requirement instead of the monitoring requirements of 40 CFR 63.174(a) and (c) and from the recordkeeping and reporting requirements of 40 CFR 63.181 and 63.182. Subpart H. [40 CFR 63.174(h)(2)]
349	[40 CFR 63.174(i)]	Connectors in gas/vapor service or light liquid service: Calculate percent leaking connectors as specified in 40 CFR 63.174(i)(1) and (i)(2). Subpart H. [40 CFR 63.174(i)]
350	[40 CFR 63.180]	Comply with the test methods and procedures requirements provided in 40 CFR 63.180. Subpart H.
351	[40 CFR 63.181]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Maintain records as specified in 40 CFR 63.181(a) through (k). Subpart H.
352	[40 CFR 63.182(b)]	Submit Initial Notification: Due within 120 days after the date of promulgation of the subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(b)(1). Subpart H. [40 CFR 63.182(b)]
353	[40 CFR 63.182(c)]	Submit Notification of Compliance Status: Due within 90 days of the compliance dates specified in the 40 CFR 63 subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(c)(1) through (c)(3). Subpart H. [40 CFR 63.182(c)]
354	[40 CFR 63.182(d)]	Submit Periodic Reports: Due semiannually starting 6 months after the Notification of Compliance Status, as required in 40 CFR 63.182(c). Include the information specified in 40 CFR 63.182(d)(2) through (d)(4). Subpart H. [40 CFR 63.182(d)]

Group: PCS 0002 G-22 Process Unit

FUG 0004 106 - G-11/12 Production Fugitive Emissions (G-22 Unit)

355	[40 CFR 63.9000(a)]	Prepare and operate at all times according to an equipment LDAR plan that describes in detail the measure that will be put in place to detect leaks and repair them in a timely fashion. Submit the plan to DEQ for comment only with the Notification of Compliance Status. (Applies only to specific components in HCl service as defined by the rule.) Subpart NNNNN. [40 CFR 63.9000(a)]
356	[40 CFR 63.9040(a)]	Demonstrate continuous compliance with 40 CFR 63 Subpart NNNNN, Table 1 and Table 2, as applicable, according to 40 CFR 63 Subpart NNNNN, Table 4 and Table 5. (Applies only to specific components in HCl service as defined by the rule.) Subpart NNNNN. [40 CFR 63.9040(a)]
357	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 0.37 lb/hr Alternate Operating Scenario (SCN0002): Emissions are from the production of G-11/12 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly average
358	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 0.37 lb/hr Alternate Operating Scenario (SCN0002): Emissions are from the production of G-11/12 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly maximum
359	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 1.61 tons/yr Alternate Operating Scenario (SCN0002): Emissions are from the production of G-11/12 in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Annual maximum
360	[LAC 33:III.501]	Comply with 40 CFR 63 Subpart H (HON), LAC 33:III.2122, and LAC 33:III.5109 (Louisiana Non-HON MACT) by implementing the Louisiana Consolidated Fugitive Emission Program Guidelines. Compliance is achieved through compliance with 40 CFR 63 Subpart H (HON). [LAC 33:III.501, LAC 33:III.2122.A, 40 CFR 63.160, LAC 33:III.5109]
361	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Compliance with the requirements of 40 CFR 63 Subpart H (HON) in accordance with the streamlining provisions in 40 CFR Part 70 Specific Condition No. 1 and 40 CFR 63 Subpart NNNNN for specific components in HCl service constitutes MACT.

FUG 0005 107 - G-143a Production Fugitive Emissions (G-22 Unit)

362	[40 CFR 63.162(c)]	Identify each piece of equipment in a process unit such that it can be distinguished readily from equipment that is not subject to 40 CFR 63 Subpart H. Subpart H. [40 CFR 63.162(c)]
363	[40 CFR 63.162(f)]	Clearly identify leaking equipment, for leaking equipment detected as specified in 40 CFR 63.163, 40 CFR 63.164, 40 CFR 63.168, 40 CFR 63.169, and 40 CFR 63.172 through 63.174. The identification may be removed after the equipment is repaired, except for valves or for connectors subject to 40 CFR 63.174(c)(1)(i). The identification on a valve may be removed after it has been monitored as specified in 40 CFR 63.168(f)(3) and 63.175(e)(i)(D), and no leak has been detected during the follow-up monitoring. If electing to comply using the provisions of 40 CFR 63.174(c)(1)(i), the identification on a connector may be removed after it is monitored as specified in 40 CFR 63.174(c)(1)(i) and no leak is detected during that monitoring. Subpart H. [40 CFR 63.162(f)]

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FUG 0005 107 - G-143a Production Fugitive Emissions (G-22 Unit)

364	[40 CFR 63.163(b)(1)]	Pumps in light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, except as provided in 40 CFR 63.162(b) and 63.163(e) through (j). If a reading of 10,000 ppm (phase I); 5,000 ppm (phase II); or 5,000 ppm (phase III, pumps handling polymerizing monomers), 2,000 ppm (phase III, pumps in food/medical service), or 1,000 ppm (phase III, all other pumps) or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(1)] Which Months: All Year Statistical Basis: None specified
365	[40 CFR 63.163(b)(3)]	Pumps in light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquids dripping from the pump seal, a leak is detected. If a leak is detected, initiate the repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(3)] Which Months: All Year Statistical Basis: None specified
366	[40 CFR 63.163(c)]	Pumps in light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.163(c)(3) and 40 CFR 63.171. Subpart H. [40 CFR 63.163(c)]
367	[40 CFR 63.163(d)(2)]	Pumps in light liquid service: Implement a quality improvement program for pumps that complies with the requirements of 40 CFR 63.176, if, in Phase III, calculated on a 6-month rolling average, the greater of either 10 percent of the pumps in a process unit or three pumps in a process unit leak. Subpart H. [40 CFR 63.163(d)(2)]
368	[40 CFR 63.163(d)(4)]	Pumps in light liquid service: Determine percent leaking pumps using the equation in 40 CFR 63.163(d)(4). Subpart H. [40 CFR 63.163(d)(4)]
369	[40 CFR 63.163(e)(1)]	Pumps in light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the pump stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(1)]
370	[40 CFR 63.163(e)(2)]	Pumps in light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid service. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(2)]
371	[40 CFR 63.163(e)(3)]	Pumps in light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(3)]
372	[40 CFR 63.163(e)(4)]	Pumps in light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquid dripping from the pump seal at the time of the weekly inspection, monitor the pump as specified in 40 CFR 63.180(b) to determine if there is a leak of organic HAP in the barrier fluid. If an instrument reading of 1,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(4)] Which Months: All Year Statistical Basis: None specified
373	[40 CFR 63.163(e)(6)(i)]	Pumps in light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)(i)]

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374	[40 CFR 63.163(e)(6)]	Pumps in light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)]
375	[40 CFR 63.163(e)]	Pumps in light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the pump is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.163(e)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)] Which Months: All Year Statistical Basis: None specified
376	[40 CFR 63.163(j)(1)]	Pumps in light liquid service (unsafe-to-monitor): Determine that the pump is unsafe-to-monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.163(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(1)]
377	[40 CFR 63.163(j)(2)]	Pumps in light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the pump as frequently as practicable during safe-to-monitor times but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(2)] Which Months: All Year Statistical Basis: None specified
378	[40 CFR 63.164(a)]	Compressors: Equip with a seal system that includes a barrier fluid system and that prevents leakage of process fluid to the atmosphere, except as provided in 40 CFR 63.162(b) and 40 CFR 63.164(h) and (i). Subpart H. [40 CFR 63.164(a)]
379	[40 CFR 63.164(b)]	Compressors: Operate the seal system with the barrier fluid at a pressure that is greater than the compressor stuffing box pressure; or equip with a barrier fluid system degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid directly into a process stream. Subpart H. [40 CFR 63.164(b)]
380	[40 CFR 63.164(c)]	Compressors: Ensure that the barrier fluid is not in light liquid service. Subpart H. [40 CFR 63.164(c)]
381	[40 CFR 63.164(d)]	Compressors: Equip each barrier fluid system as described in 40 CFR 63.164(a) through (c) with a sensor that will detect failure of the seal system, barrier fluid system, or both. Subpart H. [40 CFR 63.164(d)]
382	[40 CFR 63.164(e)(2)]	Compressors (sensor): Determine, based on design considerations and operating experience, a criterion that indicates failure of the seal system, the barrier fluid system, or both. Subpart H. [40 CFR 63.164(e)(2)]
383	[40 CFR 63.164(g)]	Compressors: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.164(g)]
384	[40 CFR 63.164(i)(2)]	Compressors (no detectable emissions): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially and annually, and at other times requested by DEQ. Comply with this requirement instead of the requirements in 40 CFR 63.164(a) through (h). Subpart H. [40 CFR 63.164(i)(2)] Which Months: All Year Statistical Basis: None specified

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385	[40 CFR 63.164]	Compressors (sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an alarm, unless the compressor is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criterion determined under 40 CFR 63.164(e)(2), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.164(g). Subpart H. Which Months: All Year Statistical Basis: None specified
386	[40 CFR 63.165(a)]	Pressure relief device in gas/vapor service: Organic HAP < 500 ppm above background except during pressure releases, as determined by the method specified in 63.180(c). Subpart H. [40 CFR 63.165(a)] Which Months: All Year Statistical Basis: None specified
387	[40 CFR 63.165(b)(1)]	Pressure relief devices in gas/vapor service: After each pressure release, return to a condition indicated by an instrument reading of less than 500 ppm above background, as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.165(b)(1)]
388	[40 CFR 63.165(b)(2)]	Pressure relief devices in gas/vapor service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) after the pressure release and being returned to organic HAP service, to confirm the condition indicated by an instrument reading of less than 500 ppm above background, as measured by the method specified in 40 CFR 63.180(c). Subpart H. [40 CFR 63.165(b)(2)] Which Months: All Year Statistical Basis: None specified
389	[40 CFR 63.165(d)(2)]	Pressure relief devices in gas/vapor service (rupture disk): After each pressure release, install a new rupture disk upstream of the pressure relief device as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.165(a) and (b). Subpart H. [40 CFR 63.165(d)(2)]
390	[40 CFR 63.166]	Sampling connection systems: Equip with a closed-purge, closed-loop, or closed-vent system, except as provided in 40 CFR 63.162(b). Operate the system as specified in 40 CFR 63.166(b). Subpart H.
391	[40 CFR 63.167]	Open-ended valves or lines: Equip with a cap, blind flange, plug, or a second valve, except as provided in 40 CFR 63.162(b) and 40 CFR 63.167(d) and (e). Ensure that the cap, blind flange, plug or second valve seals the open end at all times except during operations requiring process fluid flow through the open-ended valve or line, or during maintenance or repair. Operate each open-ended valve or line equipped with a second valve in a manner such that the valve on the process fluid end is closed before the second valve is closed. Subpart H.
392	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase II): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified
393	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase I): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected.. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified

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394	[40 CFR 63.168(d)(1)]	Valves in gas/vapor service or light liquid service (Phase III, 2 percent or greater leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly, as specified in 40 CFR 63.180(b); or implement a quality improvement program for valves that complies with the requirements of 40 CFR 63.175 and monitor quarterly. If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). If electing to implement a quality improvement program, follow the procedures in 40 CFR 63.175. Subpart H. [40 CFR 63.168(d)(1)] Which Months: All Year Statistical Basis: None specified
395	[40 CFR 63.168(d)(2)]	Valves in gas/vapor service or light liquid service (Phase III, less than 2 percent leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Permittee may elect to comply with the alternate standards in 40 CFR 63.168(d)(3) and (d)(4). Subpart H. [40 CFR 63.168(d)(2)] Which Months: All Year Statistical Basis: None specified
396	[40 CFR 63.168(e)(1)]	Valves in gas/vapor service or light liquid service: Determine percent leaking valves using the equation in 40 CFR 63.168(e)(1). Subpart H. [40 CFR 63.168(e)(1)]
397	[40 CFR 63.168(f)(3)]	Valves in gas/vapor service or light liquid service (after leak repair): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within three months (at least) after repair to determine whether the valve has resumed leaking. Subpart H. [40 CFR 63.168(f)(3)] Which Months: All Year Statistical Basis: None specified
398	[40 CFR 63.168(f)]	Valves in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.168(f)]
399	[40 CFR 63.168(h)(1)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the valve is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.168(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(1)]
400	[40 CFR 63.168(h)(2)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the valves as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(2)] Which Months: All Year Statistical Basis: None specified
401	[40 CFR 63.168(i)(1)]	Valves in gas/vapor service or light liquid service (difficult-to-monitor): Demonstrate that the valve cannot be monitored without elevating the monitoring personnel more than 2 meters above a support surface or it is not accessible at anytime in a safe manner. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (d). Subpart H. [40 CFR 63.168(i)(1)]
402	[40 CFR 63.168(i)(3)]	Valves in gas/vapor service or light liquid service (difficult-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Maintain a written plan that requires monitoring of the valves at least once per calendar year. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (d). Subpart H. [40 CFR 63.168(i)(3)] Which Months: All Year Statistical Basis: None specified

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FUG 0005 107 - G-143a Production Fugitive Emissions (G-22 Unit)

403	[40 CFR 63.169(a)]	Pumps, valves, connectors, and agitators in heavy liquid service; instrumentation systems; and pressure relief devices in liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) if evidence of a potential leak to the atmosphere is found by visible, audible, olfactory, or any other detection method. If a reading of 10,000 ppm for agitators, 5,000 ppm for pumps handling polymerizing monomers, 2,000 ppm for all other pumps (including pumps in food/medical service), or 500 ppm for valves, connectors, instrumentation systems, and pressure relief devices, or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.169(c). Subpart H. [40 CFR 63.169(a)] Which Months: All Year Statistical Basis: None specified
404	[40 CFR 63.169(c)]	Pumps, valves, connectors, and agitators in heavy liquid service; instrumentation systems; and pressure relief devices in liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.169(c)]
405	[40 CFR 63.170]	Surge control vessels and bottoms receivers: Equip with a closed-vent system that routes the organic vapors vented from the surge control vessel or bottoms receiver back to the process or to a control device that complies with the requirements of 40 CFR 63.172, except as provided in 40 CFR 63.162(b), or comply with the requirements of 40 CFR 63.119(b) or (c), if surge control vessel or bottoms receiver is not routed back to the process and meets the conditions specified in 40 CFR 63 Subpart H Table 2 or Table 3. Subpart H.
406	[40 CFR 63.172(f)(1)(i)]	Closed-vent system (hard-piping): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(1)(i)] Which Months: All Year Statistical Basis: None specified
407	[40 CFR 63.172(f)(1)(ii)]	Closed-vent system (hard-piping): Presence of a leak monitored by visual, audible, and/or olfactory annually. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(1)(ii)] Which Months: All Year Statistical Basis: None specified
408	[40 CFR 63.172(f)(2)(i)]	Closed-vent system (duct work): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(2)(i)] Which Months: All Year Statistical Basis: None specified
409	[40 CFR 63.172(f)(2)(ii)]	Closed-vent system (duct work): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually according to the procedures in 40 CFR 63.180(b). If an instrument reading greater than 500 ppm above background is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.172(h). Subpart H. [40 CFR 63.172(f)(2)(ii)] Which Months: All Year Statistical Basis: None specified
410	[40 CFR 63.172(h)]	Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.172(i). Subpart H. [40 CFR 63.172(h)]
411	[40 CFR 63.172(j)(1)]	Closed-vent system (bypass lines): Flow monitored by flow indicator once every 15 minutes. Install flow indicator at the entrance to any bypass line. Subpart H. [40 CFR 63.172(j)(1)] Which Months: All Year Statistical Basis: None specified

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412	[40 CFR 63.172(j)(1)]	Closed-vent system (bypass lines): Flow recordkeeping by electronic or hard copy once every 15 minutes. Generate records as specified in 40 CFR 63.118(a)(3). Subpart H. [40 CFR 63.172(j)(1)]
413	[40 CFR 63.172(j)(2)]	Closed-vent system (bypass lines): Secure the bypass line valve in the non-diverting position with a car-seal or a lock-and-key type configuration. Subpart H. [40 CFR 63.172(j)(2)]
414	[40 CFR 63.172(j)(2)]	Closed-vent system (bypass lines): Seal or closure mechanism monitored by visual inspection/determination monthly to ensure the valve is maintained in the non-diverting position and the vent stream is not diverted through the bypass line. Subpart H. [40 CFR 63.172(j)(2)] Which Months: All Year Statistical Basis: None specified
415	[40 CFR 63.172(k)(1)]	Closed-vent system (unsafe-to-inspect): Demonstrate that the equipment is unsafe to inspect because inspecting personnel would be exposed to an imminent or potential dangers as a consequence of complying with 40 CFR 63.172(f)(1) or (f)(2). Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(k)(1)]
416	[40 CFR 63.172(k)(2)]	Closed-vent system (unsafe-to-inspect): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires inspection of the equipment as frequently as practicable during safe-to-inspect times, but not more frequently than annually. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(k)(2)] Which Months: All Year Statistical Basis: None specified
417	[40 CFR 63.172(l)(1)]	Closed-vent system (difficult-to-inspect): Demonstrate that the equipment cannot be inspected without elevating the inspecting personnel more than 2 meters above a support surface. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(l)(1)]
418	[40 CFR 63.172(l)(2)]	Closed-vent system (difficult-to-inspect): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once every five years. Maintain a written plan that requires inspection of the equipment at least once every five years. Comply with this requirement instead of the requirements in 40 CFR 63.172(f)(1) and (f)(2). Subpart H. [40 CFR 63.172(l)(2)] Which Months: All Year Statistical Basis: None specified
419	[40 CFR 63.172(m)]	Ensure that the closed-vent system or control device is operating whenever organic HAP emissions are vented to the closed-vent system or control device. Subpart H. [40 CFR 63.172(m)]
420	[40 CFR 63.173(a)]	Agitators in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.173(c). Subpart H. [40 CFR 63.173(a)] Which Months: All Year Statistical Basis: None specified
421	[40 CFR 63.173(b)]	Agitators in gas/vapor service or light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar) for indications of liquids dripping from the agitator. If there are indications of liquids dripping from the agitator, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.173(c). Subpart H. [40 CFR 63.173(b)] Which Months: All Year Statistical Basis: None specified
422	[40 CFR 63.173(c)]	Agitators in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.173(c)]

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423	[40 CFR 63.173(d)(1)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the agitator stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(1)]
424	[40 CFR 63.173(d)(2)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid organic HAP service. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(2)]
425	[40 CFR 63.173(d)(3)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(3)]
426	[40 CFR 63.173(d)(4)]	Agitators in gas/vapor service or light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the agitator seal. If there are indications of liquid dripping from the agitator seal at the time of the weekly inspection, monitor the agitator as specified in 40 CFR 63.180(b) to determine the presence of organic HAP in the barrier fluid. If an instrument reading of 10,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.173(d)(6). Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(4)] Which Months: All Year Statistical Basis: None specified
427	[40 CFR 63.173(d)(6)(i)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(6)(i)]
428	[40 CFR 63.173(d)(6)]	Agitators in gas/vapor service and light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)(6)]
429	[40 CFR 63.173(d)]	Agitators in gas/vapor service or light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the agitator is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.173(d)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.173(d)(6). Comply with this requirement instead of the requirements in 40 CFR 63.173(a). Subpart H. [40 CFR 63.173(d)] Which Months: All Year Statistical Basis: None specified
430	[40 CFR 63.173(h)(1)]	Agitators in gas/vapor service or light liquid service (difficult to monitor): Demonstrate that the agitator cannot be monitored without elevating the monitoring personnel more than two meters above a support surface or it is not accessible at anytime in a safe manner. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(h)(1)]

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431	[40 CFR 63.173(h)(3)]	Agitators in gas/vapor service or light liquid service (difficult-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Maintain a written plan that requires monitoring of the agitator at least once per calendar year. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(h)(3)] Which Months: All Year Statistical Basis: None specified
432	[40 CFR 63.173(j)(1)]	Agitators in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the agitator is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.173(a) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(j)(1)]
433	[40 CFR 63.173(j)(2)]	Agitators in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the agitator as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.173(a) through (d). Subpart H. [40 CFR 63.173(j)(2)] Which Months: All Year Statistical Basis: None specified
434	[40 CFR 63.174(b)(1)]	Connectors in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within 12 months after the compliance date, except as provided in 40 CFR 63.174(f) through (h). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(b)(1)] Which Months: All Year Statistical Basis: None specified
435	[40 CFR 63.174(b)(2)]	Connectors in gas/vapor service or light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within the first 12 months after initial startup or by no later than 12 months after the date of promulgation of a specific subpart that references 40 CFR 63 Subpart H, whichever is later, except as specified in 40 CFR 63.174(f) through (h). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(b)(2)] Which Months: All Year Statistical Basis: None specified
436	[40 CFR 63.174(b)(3)(i)]	Connectors in gas/vapor service or light liquid service (0.5% or greater leaking): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 annually. Subpart H. [40 CFR 63.174(b)(3)(i)] Which Months: All Year Statistical Basis: None specified
437	[40 CFR 63.174(b)(3)(ii)]	Connectors in gas/vapor service or light liquid service (less than 0.5% leaking): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once every two years. Subpart H. [40 CFR 63.174(b)(3)(ii)] Which Months: All Year Statistical Basis: None specified
438	[40 CFR 63.174(c)(1)(i)]	Connectors in gas/vapor service or light liquid service (opened or otherwise had the seal broken): Presence of a leak monitored by 40 CFR 60, Appendix A, Method 21 within three months after being returned to organic HAP service or when it is reconnected. If monitoring detects a leak, repair according to the provisions of 40 CFR 63.174(d), as specified, except as provided in 40 CFR 63.174(c)(1)(ii). Subpart H. [40 CFR 63.174(c)(1)(i)] Which Months: All Year Statistical Basis: None specified
439	[40 CFR 63.174(c)(2)(i)]	Connectors in gas/vapor service or light liquid service (2 inches or less in nominal diameter): Comply with the requirements of 40 CFR 63.169. Subpart H. [40 CFR 63.174(c)(2)(i)]

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440	[40 CFR 63.174(c)(2)(ii)]	Connectors in gas/vapor service or light liquid service (2 inches or less in nominal diameter): Organic HAP monitored by technically sound method within three months after being returned to organic HAP service after having been opened or otherwise had the seal broken. If monitoring detects a leak, implement repair provisions in 40 CFR 63.174(d). Subpart H. [40 CFR 63.174(c)(2)(ii)] Which Months: All Year Statistical Basis: None specified
441	[40 CFR 63.174(d)]	Connectors in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after it each leak is detected, except as provided in 40 CFR 63.171 and 63.174(g). Subpart H. [40 CFR 63.174(d)]
442	[40 CFR 63.174(f)(1)]	Connectors in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the connector is unsafe to monitor because personnel would be exposed to an immediate danger as a result of complying with 40 CFR 63.174(a) through (c). Comply with this requirement instead of the requirements in 40 CFR 63.174(a). Subpart H. [40 CFR 63.174(f)(1)]
443	[40 CFR 63.174(f)(2)]	Connectors in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of connectors as frequently as practicable during safe to monitor times, but not more frequently than the periodic schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.174(a). Subpart H. [40 CFR 63.174(f)(2)] Which Months: All Year Statistical Basis: None specified
444	[40 CFR 63.174(g)]	Connectors in gas/vapor service or light liquid service (unsafe-to-repair): Demonstrate that repair personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.174(d). Comply with this requirement instead of the requirements in 40 CFR 63.174(a), (d), and (e). Subpart H. [40 CFR 63.174(g)]
445	[40 CFR 63.174(h)(2)]	Connectors in gas/vapor service or light liquid service (inaccessible, ceramic, or ceramic-lined): Make a first attempt at repair within 5 days after leak is detected by visual, audible, olfactory or other means, and complete repairs no later than 15 calendar days after leak is detected, except as provided in 40 CFR 63.171 and 63.174(g). Comply with this requirement instead of the monitoring requirements of 40 CFR 63.174(a) and (c) and from the recordkeeping and reporting requirements of 40 CFR 63.181 and 63.182. Subpart H. [40 CFR 63.174(h)(2)]
446	[40 CFR 63.174(i)]	Connectors in gas/vapor service or light liquid service: Calculate percent leaking connectors as specified in 40 CFR 63.174(i)(1) and (i)(2). Subpart H. [40 CFR 63.174(i)]
447	[40 CFR 63.180]	Comply with the test methods and procedures requirements provided in 40 CFR 63.180. Subpart H.
448	[40 CFR 63.181]	Equipment/operational data recordkeeping by electronic or hard copy at the regulation's specified frequency. Maintain records as specified in 40 CFR 63.181(a) through (k). Subpart H.
449	[40 CFR 63.182(b)]	Submit Initial Notification: Due within 120 days after the date of promulgation of the subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(b)(1). Subpart H. [40 CFR 63.182(b)]
450	[40 CFR 63.182(c)]	Submit Notification of Compliance Status: Due within 90 days of the compliance dates specified in the 40 CFR 63 subpart that references 40 CFR 63 Subpart H. Include the information specified in 40 CFR 63.182(c)(1) through (c)(3). Subpart H. [40 CFR 63.182(c)]
451	[40 CFR 63.182(d)]	Submit Periodic Reports: Due semiannually starting 6 months after the Notification of Compliance Status, as required in 40 CFR 63.182(c). Include the information specified in 40 CFR 63.182(d)(2) through (d)(4). Subpart H. [40 CFR 63.182(d)]

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452	[40 CFR 63.9000(a)]	Prepare and operate at all times according to an equipment LDAR plan that describes in detail the measure that will be put in place to detect leaks and repair them in a timely fashion. Submit the plan to DEQ for comment only with the Notification of Compliance Status. (Applies only to specific components in HCl service as defined by the rule.) Subpart NNNNN. [40 CFR 63.9000(a)]
453	[40 CFR 63.9040(a)]	Demonstrate continuous compliance with 40 CFR 63 Subpart NNNNN, Table 1 and Table 2, as applicable, according to 40 CFR 63 Subpart NNNNN, Table 4 and Table 5. (Applies only to specific components in HCl service as defined by the rule.) Subpart NNNNN. [40 CFR 63.9040(a)]
454	[LAC 33:III.501.C.6]	Antimony <= 0.06 tons/yr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Annual maximum
455	[LAC 33:III.501.C.6]	Antimony <= 0.01 lb/hr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly maximum
456	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 1.05 lb/hr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly maximum
457	[LAC 33:III.501.C.6]	Antimony <= 0.01 lb/hr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly average
458	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 4.58 tons/yr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Annual maximum
459	[LAC 33:III.501.C.6]	Hydrogen fluoride <= 1.05 lb/hr Alternate Operating Scenario (SCN0003): Emissions are from the production of G-143a in the G-22 Process Unit only. Which Months: All Year Statistical Basis: Hourly average
460	[LAC 33:III.501]	Comply with 40 CFR 63 Subpart H (HON), LAC 33:III.2122, and LAC 33:III.5109 (Louisiana Non-HON MACT) by implementing the Louisiana Consolidated Fugitive Emission Program Guidelines. Compliance is achieved through compliance with 40 CFR 63 Subpart H (HON). [LAC 33:III.501, LAC 33:III.2122.A, 40 CFR 63.160, LAC 33:III.5109]
461	[LAC 33:III.5109.A]	Control emissions of toxic air pollutants to a degree that constitutes Maximum Achievable Control Technology (MACT) as approved by DEQ. Compliance with the requirements of 40 CFR 63 Subpart H (HON) in accordance with the streamlining provisions in 40 CFR Part 70 Specific Condition No. 1 and 40 CFR 63 Subpart NNNNN for specific components in HCl service constitutes MACT.

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462	[40 CFR 63.162(c)]	Identify each piece of equipment in a process unit such that it can be distinguished readily from equipment that is not subject to 40 CFR 63 Subpart H. Subpart H. [40 CFR 63.162(c)]

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463	[40 CFR 63.162(f)]	Clearly identify leaking equipment, for leaking equipment detected as specified in 40 CFR 63.163, 40 CFR 63.164, 40 CFR 63.168, 40 CFR 63.169, and 40 CFR 63.172 through 63.174. The identification may be removed after the equipment is repaired, except for valves or for connectors subject to 40 CFR 63.174(c)(1)(i). The identification on a valve may be removed after it has been monitored as specified in 40 CFR 63.168(f)(3) and 63.175(e)(i)(D), and no leak has been detected during the follow-up monitoring. If electing to comply using the provisions of 40 CFR 63.174(c)(1)(i), the identification on a connector may be removed after it is monitored as specified in 40 CFR 63.174(c)(1)(i) and no leak is detected during that monitoring. Subpart H. [40 CFR 63.162(f)]
464	[40 CFR 63.163(b)(1)]	Pumps in light liquid service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly to detect leaks, except as provided in 40 CFR 63.162(b) and 63.163(e) through (j). If a reading of 10,000 ppm (phase I); 5,000 ppm (phase II); or 5,000 ppm (phase III, pumps handling polymerizing monomers), 2,000 ppm (phase III, pumps in food/medical service), or 1,000 ppm (phase III, all other pumps) or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(1)] Which Months: All Year Statistical Basis: None specified
465	[40 CFR 63.163(b)(3)]	Pumps in light liquid service: Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquids dripping from the pump seal, a leak is detected. If a leak is detected, initiate the repair provisions specified in 40 CFR 63.163(c). Subpart H. [40 CFR 63.163(b)(3)] Which Months: All Year Statistical Basis: None specified
466	[40 CFR 63.163(c)]	Pumps in light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.163(c)(3) and 40 CFR 63.171. Subpart H. [40 CFR 63.163(c)]
467	[40 CFR 63.163(d)(2)]	Pumps in light liquid service: Implement a quality improvement program for pumps that complies with the requirements of 40 CFR 63.176, if, in Phase III, calculated on a 6-month rolling average, the greater of either 10 percent of the pumps in a process unit or three pumps in a process unit leak. Subpart H. [40 CFR 63.163(d)(2)]
468	[40 CFR 63.163(d)(4)]	Pumps in light liquid service: Determine percent leaking pumps using the equation in 40 CFR 63.163(d)(4). Subpart H. [40 CFR 63.163(d)(4)]
469	[40 CFR 63.163(e)(1)]	Pumps in light liquid service (dual mechanical seal system): Operate with the barrier fluid at a pressure that is at all times greater than the pump stuffing box pressure; or equip with a barrier fluid degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid into a process stream. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(1)]
470	[40 CFR 63.163(e)(2)]	Pumps in light liquid service (dual mechanical seal system): Ensure that the barrier fluid is not in light liquid service. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(2)]
471	[40 CFR 63.163(e)(3)]	Pumps in light liquid service (dual mechanical seal system): Equip barrier fluid system with a sensor that will detect failure of the seal system, barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(3)]

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472	[40 CFR 63.163(e)(4)]	Pumps in light liquid service (dual mechanical seal system): Presence of a leak monitored by visual inspection/determination weekly (calendar). Monitor for indications of liquids dripping from the pump seal. If there are indications of liquid dripping from the pump seal at the time of the weekly inspection, monitor the pump as specified in 40 CFR 63.180(b) to determine if there is a leak of organic HAP in the barrier fluid. If an instrument reading of 1,000 ppm or greater is measured, a leak is detected. If a leak is detected, initiate the repair provisions in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(4)] Which Months: All Year Statistical Basis: None specified
473	[40 CFR 63.163(e)(6)(i)]	Pumps in light liquid service (dual mechanical seal system): Determine, based on design considerations and operating experience, criteria that indicates failure of the seal system, the barrier fluid system, or both. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)(i)]
474	[40 CFR 63.163(e)(6)]	Pumps in light liquid service (dual mechanical seal system): Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)(6)]
475	[40 CFR 63.163(e)]	Pumps in light liquid service (dual mechanical seal system - sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an audible alarm unless the pump is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criteria established in 40 CFR 63.163(e)(6), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.163(e)(6). Comply with this requirement instead of the requirements in 40 CFR 63.163(a) through (d). Subpart H. [40 CFR 63.163(e)] Which Months: All Year Statistical Basis: None specified
476	[40 CFR 63.163(j)(1)]	Pumps in light liquid service (unsafe-to-monitor): Determine that the pump is unsafe-to-monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.163(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(1)]
477	[40 CFR 63.163(j)(2)]	Pumps in light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the pump as frequently as practicable during safe-to-monitor times but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.163(b) through (e). Subpart H. [40 CFR 63.163(j)(2)] Which Months: All Year Statistical Basis: None specified
478	[40 CFR 63.164(a)]	Compressors: Equip with a seal system that includes a barrier fluid system and that prevents leakage of process fluid to the atmosphere, except as provided in 40 CFR 63.162(b) and 40 CFR 63.164(h) and (i). Subpart H. [40 CFR 63.164(a)]
479	[40 CFR 63.164(b)]	Compressors: Operate the seal system with the barrier fluid at a pressure that is greater than the compressor stuffing box pressure; or equip with a barrier fluid system degassing reservoir that is routed to a process or fuel gas system or connected by a closed-vent system to a control device that complies with the requirements of 40 CFR 63.172; or equip with a closed-loop system that purges the barrier fluid directly into a process stream. Subpart H. [40 CFR 63.164(b)]
480	[40 CFR 63.164(c)]	Compressors: Ensure that the barrier fluid is not in light liquid service. Subpart H. [40 CFR 63.164(c)]
481	[40 CFR 63.164(d)]	Compressors: Equip each barrier fluid system as described in 40 CFR 63.164(a) through (c) with a sensor that will detect failure of the seal system, barrier fluid system, or both. Subpart H. [40 CFR 63.164(d)]

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482	[40 CFR 63.164(e)(2)]	Compressors (sensor): Determine, based on design considerations and operating experience, a criterion that indicates failure of the seal system, the barrier fluid system, or both. Subpart H. [40 CFR 63.164(e)(2)]
483	[40 CFR 63.164(g)]	Compressors: Make a first attempt at repair no later than 5 calendar days after each leak is detected, and complete repairs no later than 15 calendar days after each leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.164(g)]
484	[40 CFR 63.164(i)(2)]	Compressors (no detectable emissions): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once initially and annually, and at other times requested by DEQ. Comply with this requirement instead of the requirements in 40 CFR 63.164(a) through (h). Subpart H. [40 CFR 63.164(i)(2)] Which Months: All Year Statistical Basis: None specified
485	[40 CFR 63.164]	Compressors (sensor): Equipment/operational data monitored by visual inspection/determination daily, or equip with an alarm, unless the compressor is located within the boundary of an unmanned plant site. If the sensor indicates failure of the seal system, the barrier fluid system, or both based on the criterion determined under 40 CFR 63.164(e)(2), a leak is detected. If a leak is detected, initiate repair provisions specified in 40 CFR 63.164(g). Subpart H. Which Months: All Year Statistical Basis: None specified
486	[40 CFR 63.165(a)]	Pressure relief device in gas/vapor service: Organic HAP < 500 ppm above background except during pressure releases, as determined by the method specified in 63.180(c). Subpart H. [40 CFR 63.165(a)] Which Months: All Year Statistical Basis: None specified
487	[40 CFR 63.165(b)(1)]	Pressure relief devices in gas/vapor service: After each pressure release, return to a condition indicated by an instrument reading of less than 500 ppm above background, as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.165(b)(1)]
488	[40 CFR 63.165(b)(2)]	Pressure relief devices in gas/vapor service: Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 within 5 days (calendar) after the pressure release and being returned to organic HAP service, to confirm the condition indicated by an instrument reading of less than 500 ppm above background, as measured by the method specified in 40 CFR 63.180(c). Subpart H. [40 CFR 63.165(b)(2)] Which Months: All Year Statistical Basis: None specified
489	[40 CFR 63.165(d)(2)]	Pressure relief devices in gas/vapor service (rupture disk): After each pressure release, install a new rupture disk upstream of the pressure relief device as soon as practicable, but no later than 5 calendar days after each pressure release, except as provided in 40 CFR 63.171. Comply with this requirement instead of the requirements in 40 CFR 63.165(a) and (b). Subpart H. [40 CFR 63.165(d)(2)]
490	[40 CFR 63.166]	Sampling connection systems: Equip with a closed-purge, closed-loop, or closed-vent system, except as provided in 40 CFR 63.162(b). Operate the system as specified in 40 CFR 63.166(b). Subpart H.
491	[40 CFR 63.167]	Open-ended valves or lines: Equip with a cap, blind flange, plug, or a second valve, except as provided in 40 CFR 63.162(b) and 40 CFR 63.167(d) and (e). Ensure that the cap, blind flange, plug or second valve seals the open end at all times except during operations requiring process fluid flow through the open-ended valve or line, or during maintenance or repair. Operate each open-ended valve or line equipped with a second valve in a manner such that the valve on the process fluid end is closed before the second valve is closed. Subpart H.

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492	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase II): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified
493	[40 CFR 63.168(c)]	Valves in gas/vapor service or light liquid service (Phase I): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 10,000 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Subpart H. [40 CFR 63.168(c)] Which Months: All Year Statistical Basis: None specified
494	[40 CFR 63.168(d)(1)]	Valves in gas/vapor service or light liquid service (Phase III, 2 percent or greater leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 monthly, as specified in 40 CFR 63.180(b); or implement a quality improvement program for valves that complies with the requirements of 40 CFR 63.175 and monitor quarterly. If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). If electing to implement a quality improvement program, follow the procedures in 40 CFR 63.175. Subpart H. [40 CFR 63.168(d)(1)] Which Months: All Year Statistical Basis: None specified
495	[40 CFR 63.168(d)(2)]	Valves in gas/vapor service or light liquid service (Phase III, less than 2 percent leaking valves): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 quarterly, as specified in 40 CFR 63.180(b). If an instrument reading of 500 ppm or greater is recorded, a leak is detected. If a leak is detected, initiate repair provisions in 40 CFR 63.168(f). Permittee may elect to comply with the alternate standards in 40 CFR 63.168(d)(3) and (d)(4). Subpart H. [40 CFR 63.168(d)(2)] Which Months: All Year Statistical Basis: None specified
496	[40 CFR 63.168(e)(1)]	Valves in gas/vapor service or light liquid service: Determine percent leaking valves using the equation in 40 CFR 63.168(e)(1). Subpart H. [40 CFR 63.168(e)(1)]
497	[40 CFR 63.168(f)(3)]	Valves in gas/vapor service or light liquid service (after leak repair): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 once within three months (at least) after repair to determine whether the valve has resumed leaking. Subpart H. [40 CFR 63.168(f)(3)] Which Months: All Year Statistical Basis: None specified
498	[40 CFR 63.168(f)]	Valves in gas/vapor service or light liquid service: Make a first attempt at repair no later than 5 calendar days after a leak is detected, and complete repairs no later than 15 calendar days after the leak is detected, except as provided in 40 CFR 63.171. Subpart H. [40 CFR 63.168(f)]
499	[40 CFR 63.168(h)(1)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Demonstrate that the valve is unsafe to monitor because monitoring personnel would be exposed to an immediate danger as a consequence of complying with 40 CFR 63.168(b) through (d). Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(1)]
500	[40 CFR 63.168(h)(2)]	Valves in gas/vapor service or light liquid service (unsafe-to-monitor): Organic HAP monitored by 40 CFR 60, Appendix A, Method 21 at the regulation's specified frequency. Maintain a written plan that requires monitoring of the valves as frequently as practicable during safe-to-monitor times, but not more frequently than the periodic monitoring schedule otherwise applicable. Comply with this requirement instead of the requirements in 40 CFR 63.168(b) through (f). Subpart H. [40 CFR 63.168(h)(2)] Which Months: All Year Statistical Basis: None specified